

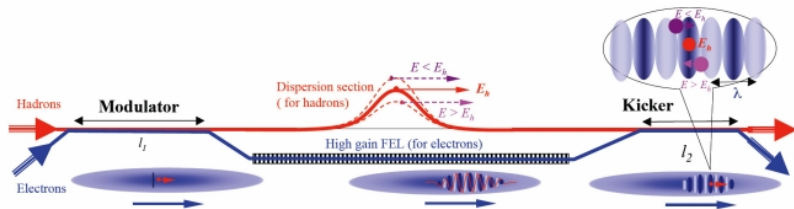
SIMULATIONS FOR COHERENT ELECTRON COOLING

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Schematic of CEC



Three sections of CEC

- Modulator : ion imprints a density wake on the electron distribution.
- Amplifier : density wake is amplified (high gain FEL).
- Kicker : amplified wake interacts with the ion.

Electron beam

- Energy : $\gamma = 42.9$
- Energy spread : $1e-3$
- Peak current : $100[\text{A}]$
- Full bunch length : $10[\text{ps}]$
- Charge : $10[\text{nC}]$
- RMS emittance : $5\pi[\text{mm mrad}]$
- β at modulator and kicker : $4[\text{m}]$

Ion beam

- Energy : $\gamma = 42.9$
- Species : Au^{+79}
- Bunch intensity : $1e+9$
- RMS bunch length : $2[\text{ns}]$
- RMS emittance : $2\pi[\text{mm mrad}]$

Simulation tools

SPACE

- A parallel, relativistic, 3D electromagnetic Particle-in-Cell (PIC) code.
- Various boundary conditions : Dirichlet, periodic, open, mixed.
- Used for modulator and kicker simulations

GENESIS

- Used for FEL simulations (amplifier)

- Mechanism for modulation process is Coulomb interactions between ions and surrounding electrons.
- Relative density modulation is orders of magnitudes smaller than unity for relativistic beam energy.
- We treat each ion individually and use superposition principle to obtain net responses of electrons to all ions in the beam.
- One ion and a slice of electron beam (3×10^7 electrons) are used in modulator simulations.

Thermal velocity

Kappa-2 velocity distribution is used to model the electron temperature.

$$f_0(\vec{v}) = \frac{n_0}{\pi^2 \beta_x \beta_y \beta_z} \left(1 + \frac{(v_x + v_{0x})^2}{\beta_x^2} + \frac{(v_y + v_{0y})^2}{\beta_y^2} + \frac{(v_z + v_{0z})^2}{\beta_z^2} \right)^{-2}$$

β_x , β_y and β_z describes the electron beam' s three-dimensional temperatures.

$\vec{v}_0 = (v_{0x}, v_{0y}, v_{0z})$ is the ion velocity.

Shot noise

$$\frac{\text{shot noise}}{\text{modulation signal}} \approx 1e + 5$$

- Perform two simulations with identical initial electron distribution.
- One simulation operates only with electron beam, the other simulation contains the electron beam and an ion.
- Take difference of the final electron distributions between the two simulations to obtain the influences of the ion.

Notations

- n_z : Longitudinal density distribution
- v_z : Longitudinal velocity distribution
- n_x : Horizontal density distribution
- v_x : Horizontal velocity distribution
- n_y : Vertical density distribution
- v_y : Vertical velocity distribution

Numerical convergence

- Identical initial particle distribution
- Different mesh refinements :
 - 5 grids per Debye Length
 - 20 grids per Debye Length
- Different number of macro electrons :
 - 3×10^5 with representing number 100
 - 3×10^7 with representing number 1

Numerical convergence, n_z

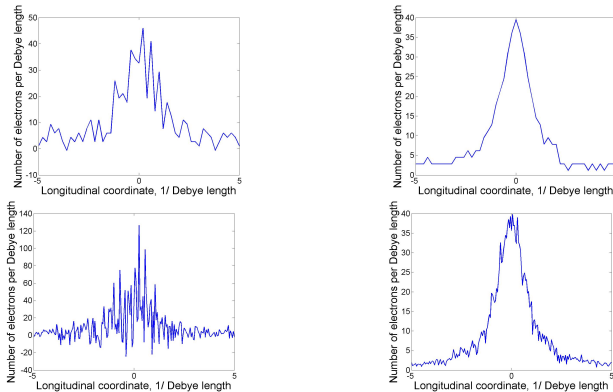


Figure: Coarse mesh (top), fine mesh (bottom), less macro particles (left), more macro particles (right).

Numerical convergence, v_z

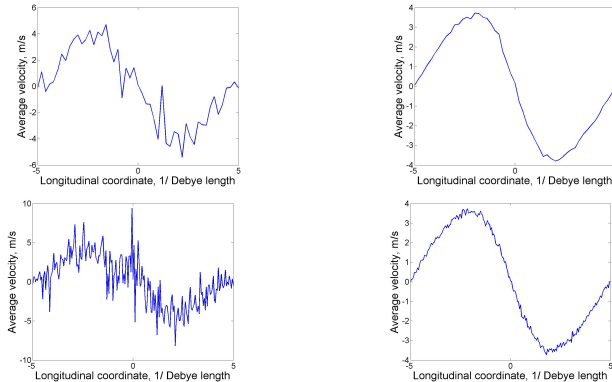
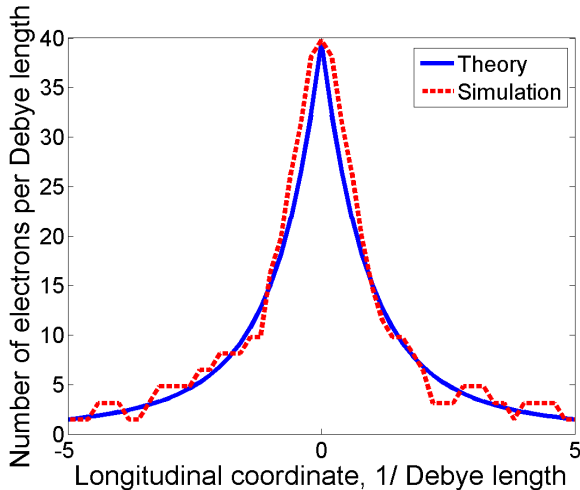


Figure: Coarse mesh (top), fine mesh (bottom), less macro particles (left), more macro particles (right).

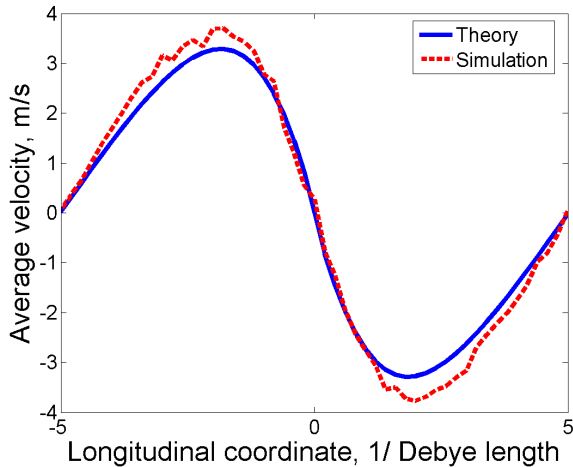
Three sets of modulator simulations

- Distribution : Uniform
Boundary : Periodic
External field : No
Analytical solution exists
- Distribution : Uniform in z , Gaussian in x and y
Boundary : Periodic in z , open in x and y
External field : Continuous focusing
- Distribution : Uniform in z , Gaussian in x and y
Boundary : Periodic in z , open in x and y
External field : Quadrupoles focusing

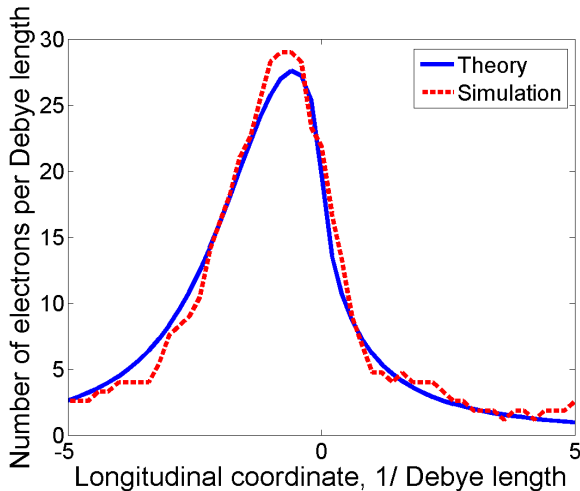
Comparison of nz, stationary ion



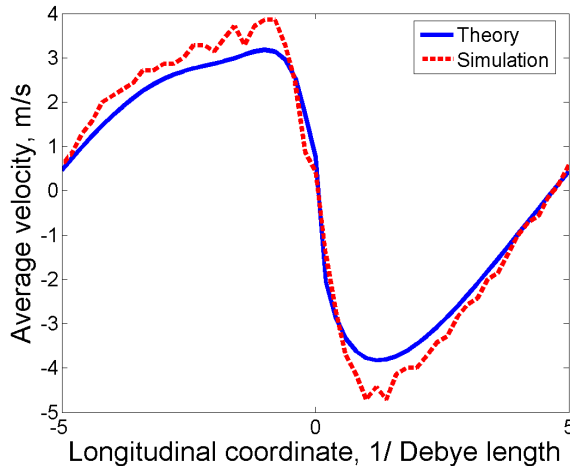
Comparison of v_z , stationary ion



Comparison of n_z , moving ion



Comparison of v_z , moving ion



Electron beam expands in transverse because of

- Thermal velocity
- Space charge effect

Focusing field

- Focusing field compensating thermal expansion

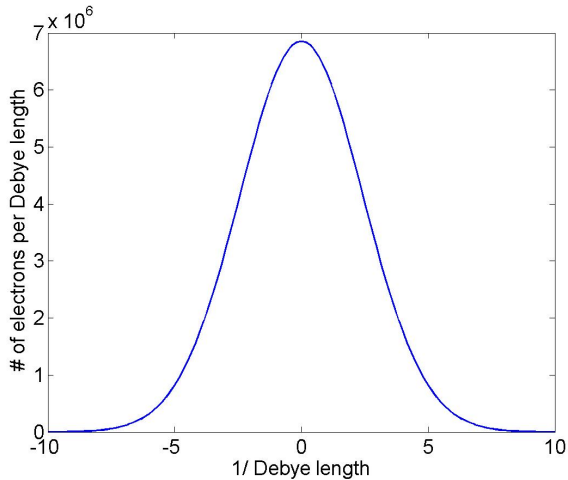
$$E_0(x) = \frac{m_e}{e} \frac{\beta^2}{r_0^2} (x - x_0)$$

- Focusing field compensating space charge expansion

$$E_1(x) = \frac{q}{2\pi\epsilon_0(x - x_0)} \left(1 - e^{-(x-x_0)^2/2r_0^2} \right)$$

- x is radial coordinate, x_0 and r_0 are center and RMS of x , β is RMS velocity of electron beam, q is line charge density of electron beam

Initial n_z



vz in continuous focusing

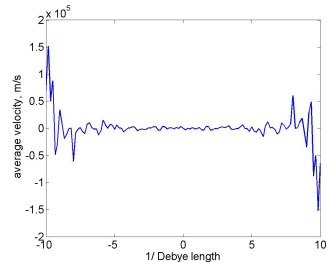
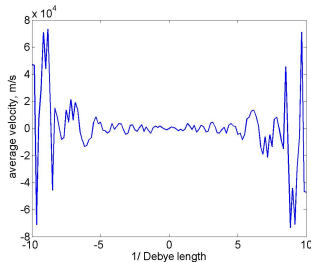
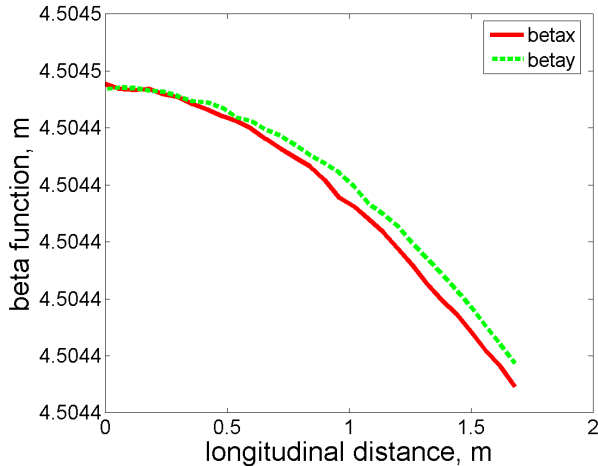
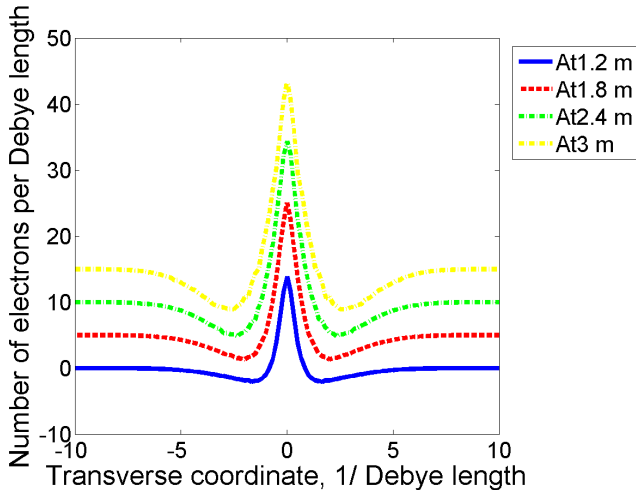


Figure: Initial (left) and final (right) v_z

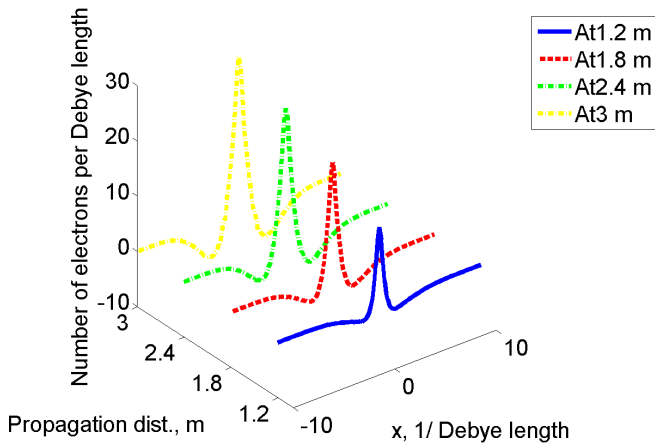
Beam size in continuous focusing



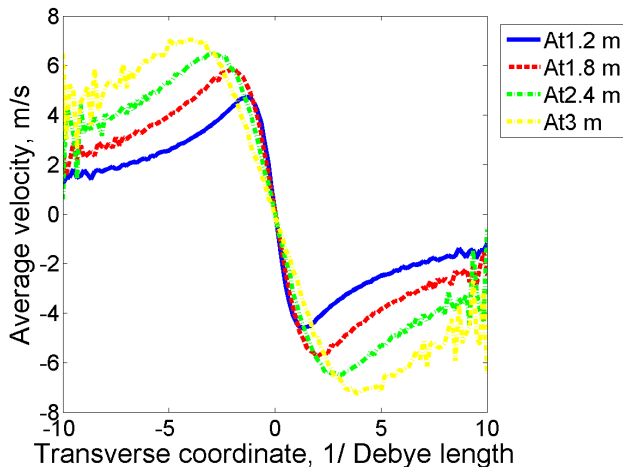
nx, ion at center



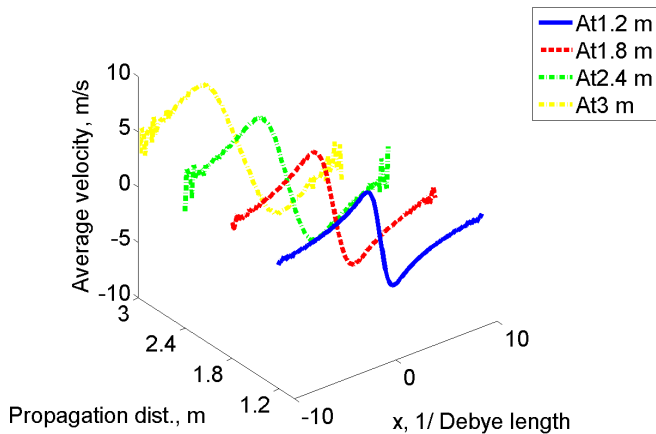
nx, ion at center



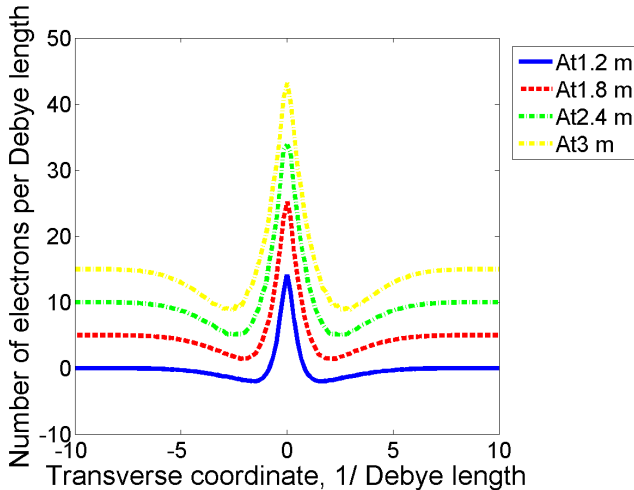
v_x , ion at center



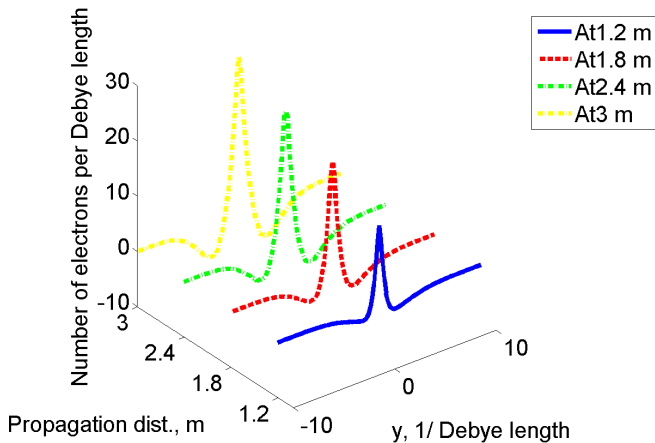
v_x , ion at center



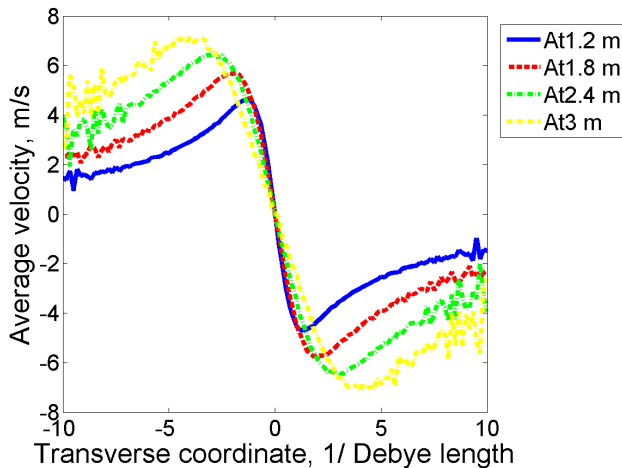
ny, ion at center



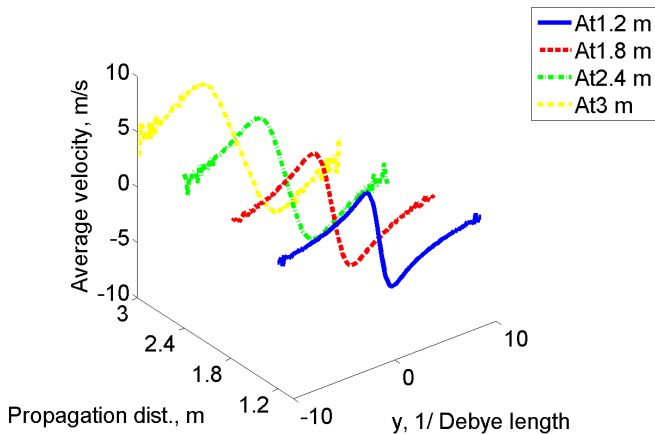
n_y , ion at center



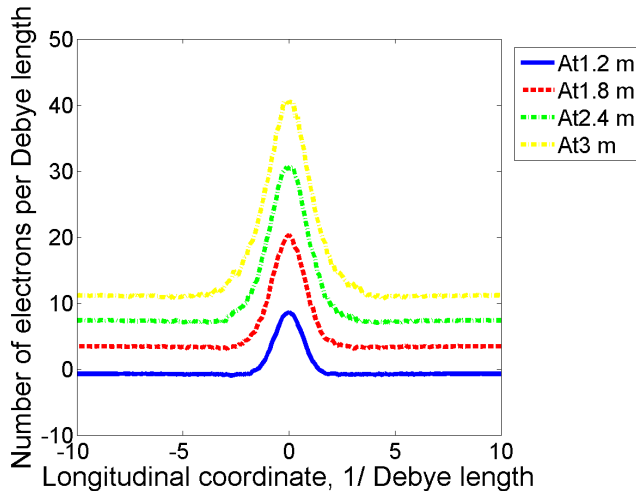
v_y , ion at center



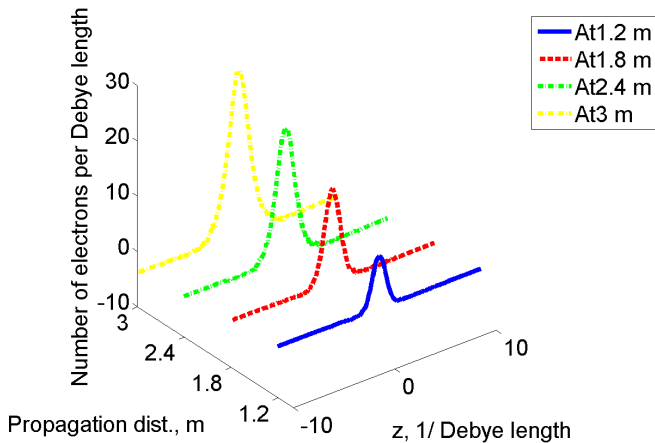
vy, ion at center



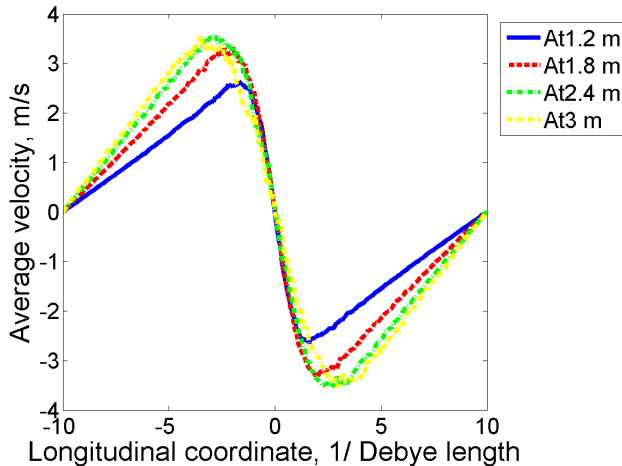
nz, ion at center



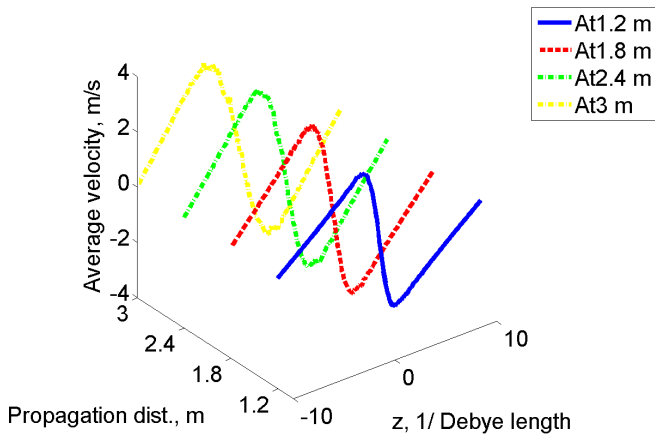
nz, ion at center



v_z , ion at center

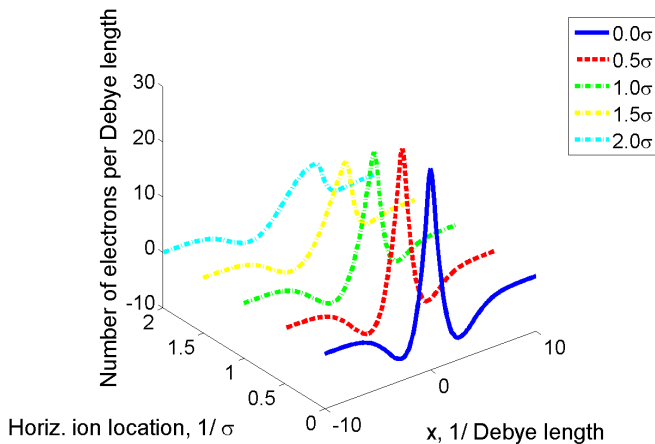


v_z , ion at center

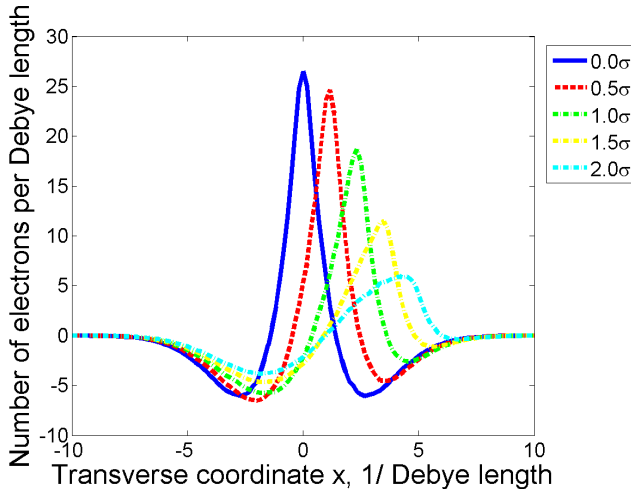


- Electron beam has Gaussian distribution in transverse
- Location of ion affects modulation process
- Typical ion locations are 0.5σ , 1.0σ , 1.5σ and 2.0σ off center of the Gaussian electron beam, where σ is RMS transverse size of electron beam

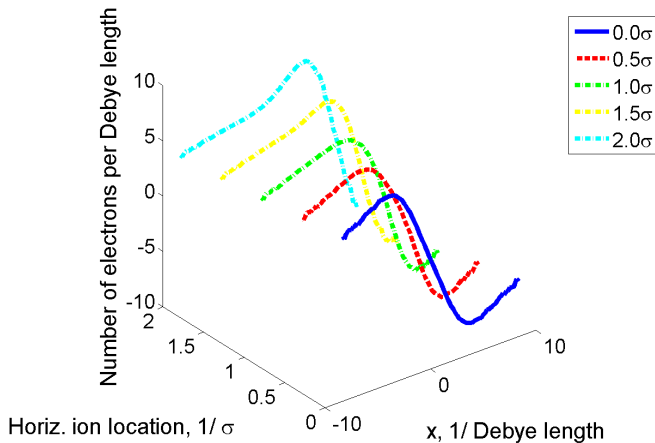
nx, various ion locations



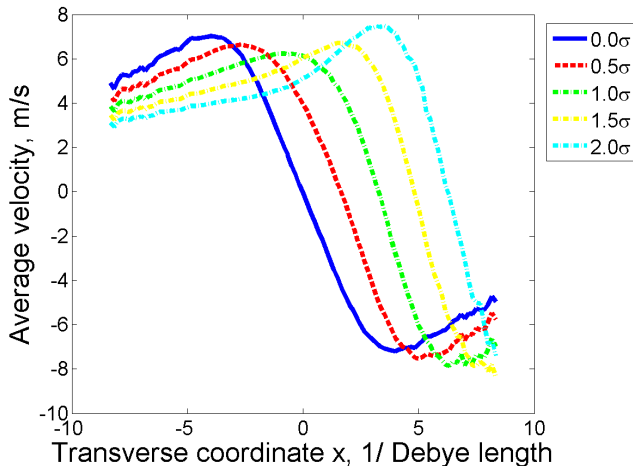
n_x , various ion locations



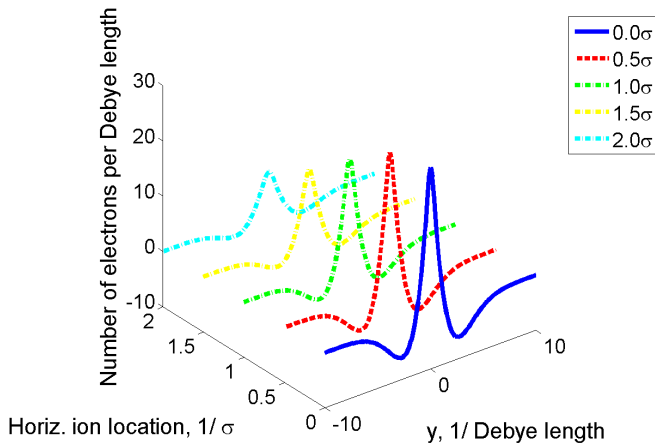
v_x , various ion locations



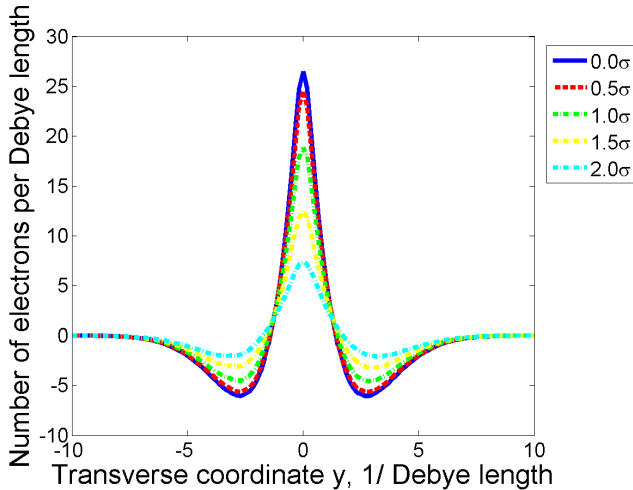
v_x , various ion locations



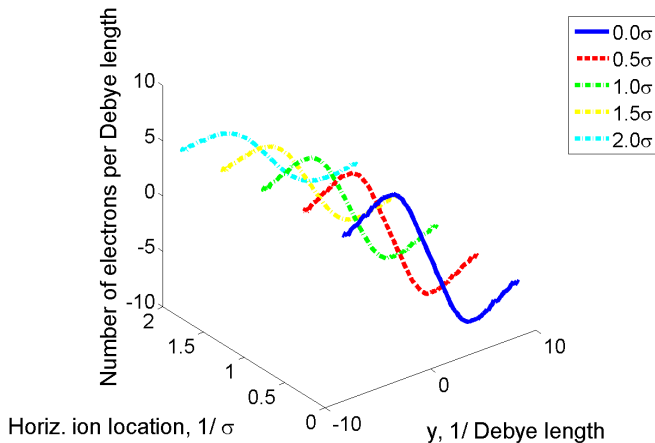
ny, various ion locations



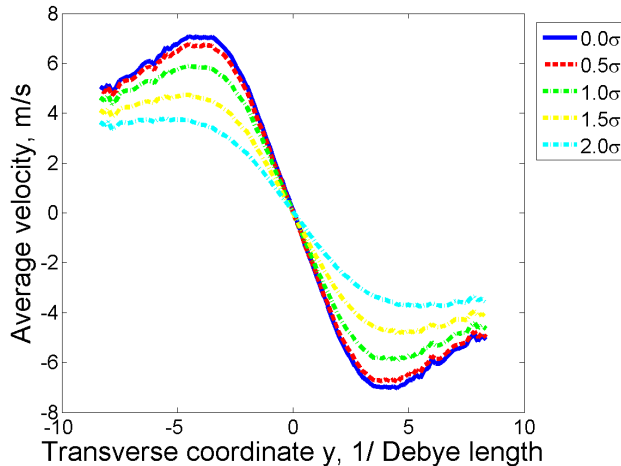
ny, various ion locations



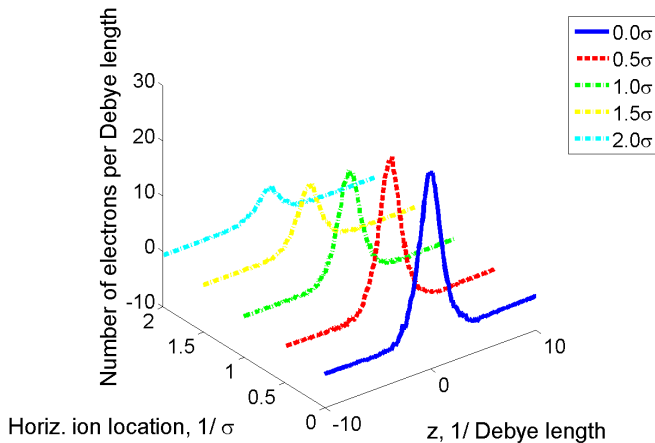
vy, various ion locations



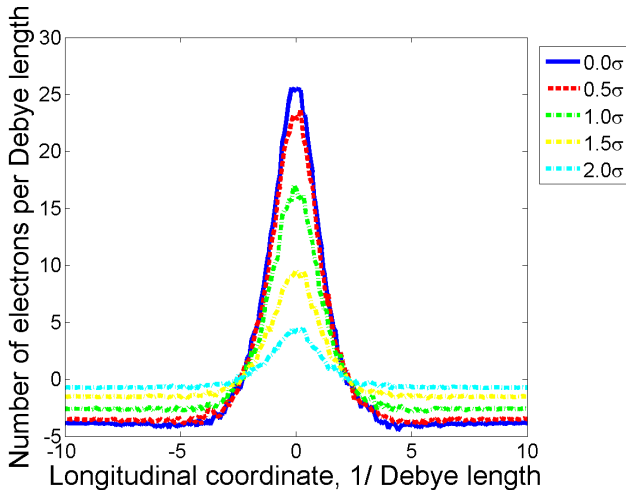
v_y , various ion locations



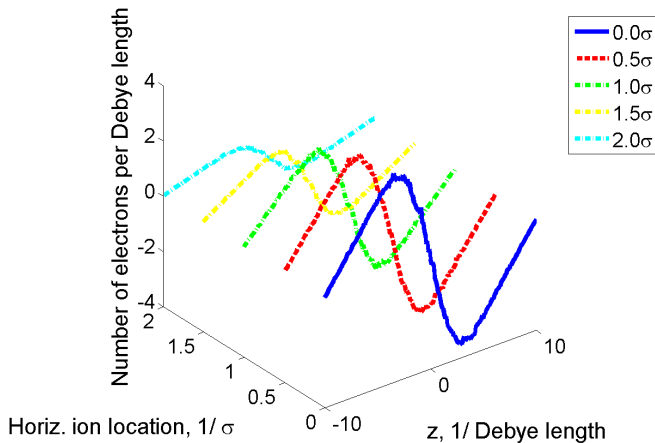
nz, various ion locations



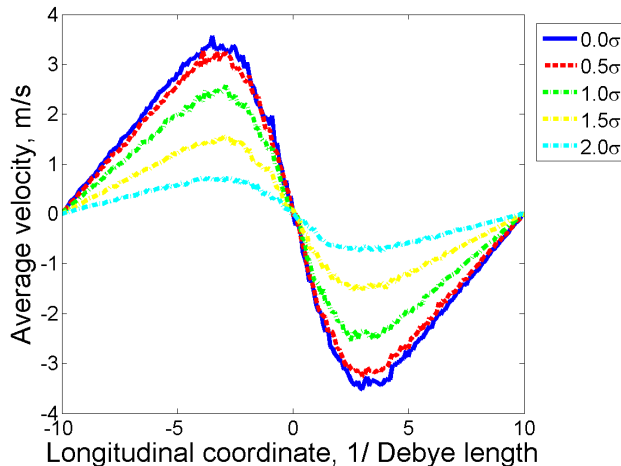
nz, various ion locations



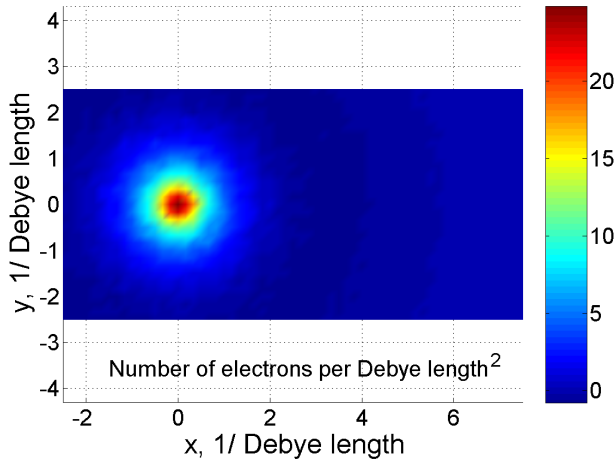
vz, various ion locations



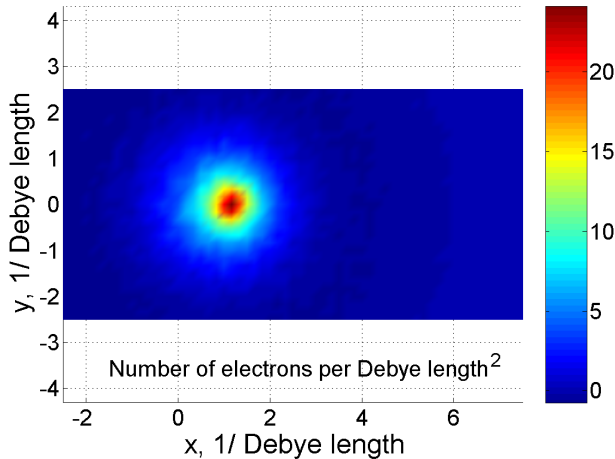
v_z , various ion locations



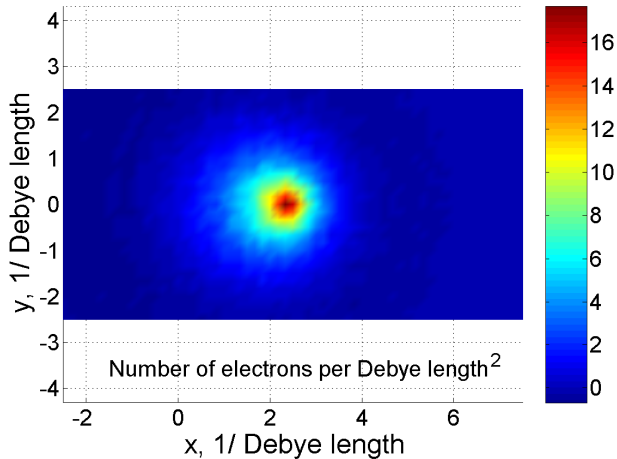
nxy, ion at center



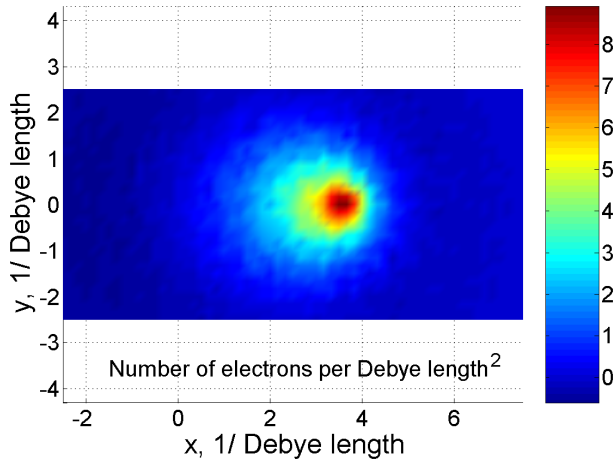
nxy, ion 0.5σ off center



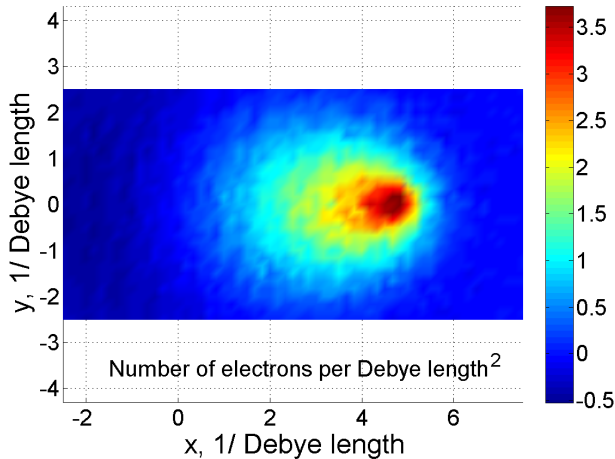
nxy, ion 1.0σ off center



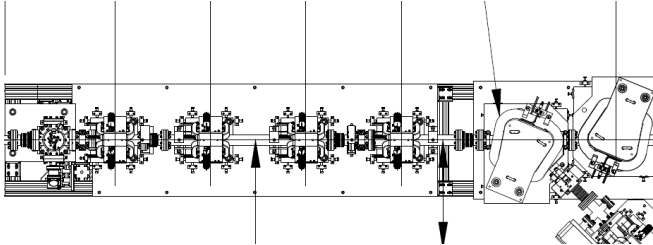
nxy, ion 1.5σ off center



nxy, ion 2.0σ off center



Layout



Hard edge

$$B_y = K \cdot x$$

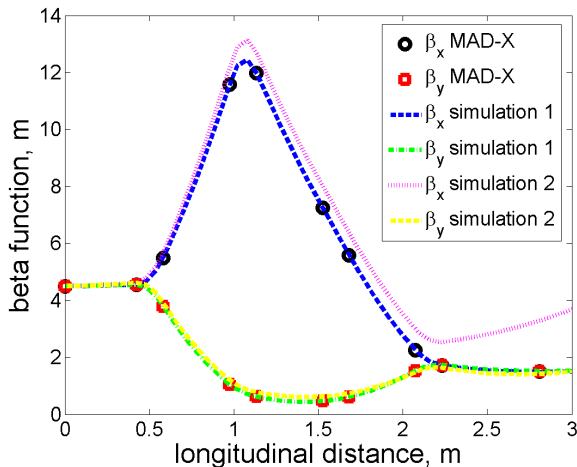
$$B_x = K \cdot y$$

Soft edge

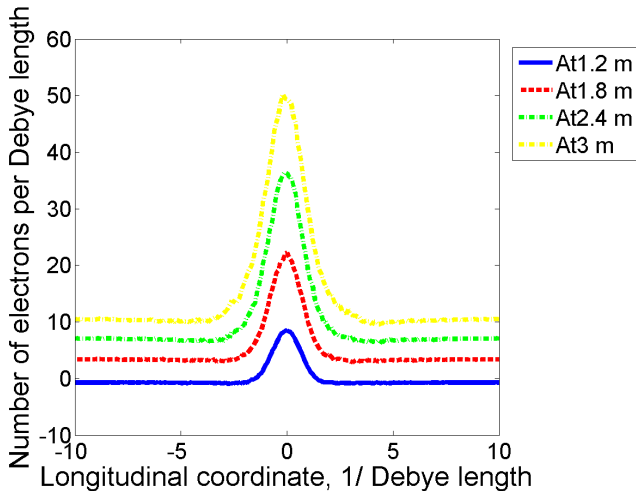
$$\begin{pmatrix} B_x \\ B_y \\ B_z \end{pmatrix} = -\frac{G}{b1} \cdot \begin{pmatrix} B_{\text{fringe},x}(b1\ x, b1\ y, b1\ (z - \frac{1}{2}L)) + B_{\text{fringe},x}(b1\ x, b1\ y, b1\ (-z - \frac{1}{2}L)) \\ B_{\text{fringe},y}(b1\ x, b1\ y, b1\ (z - \frac{1}{2}L)) + B_{\text{fringe},y}(b1\ x, b1\ y, b1\ (-z - \frac{1}{2}L)) \\ B_{\text{fringe},z}(b1\ x, b1\ y, b1\ (z - \frac{1}{2}L)) - B_{\text{fringe},z}(b1\ x, b1\ y, b1\ (-z - \frac{1}{2}L)) \end{pmatrix}$$

$$\mathbf{B}_{\text{fringe}}(x, y, z) = \frac{1}{4} \begin{pmatrix} -y - 2 \arctan\left(-\frac{\sin(y)}{e^{-z} + \cos(y)}\right) + \frac{y \sinh(z)}{\cos(x) + \cosh(z)} \\ -x - 2 \arctan\left(-\frac{\sin(x)}{e^{-z} + \cos(x)}\right) + \frac{x \sinh(z)}{\cos(y) + \cosh(z)} \\ \frac{y \sin(x)}{\cos(x) + \cosh(z)} + \frac{x \sin(y)}{\cos(y) + \cosh(z)} \end{pmatrix}$$

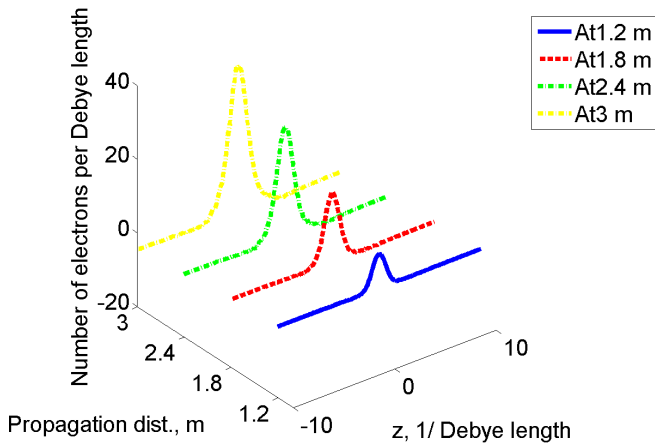
Beta function changes in quadrupoles fields



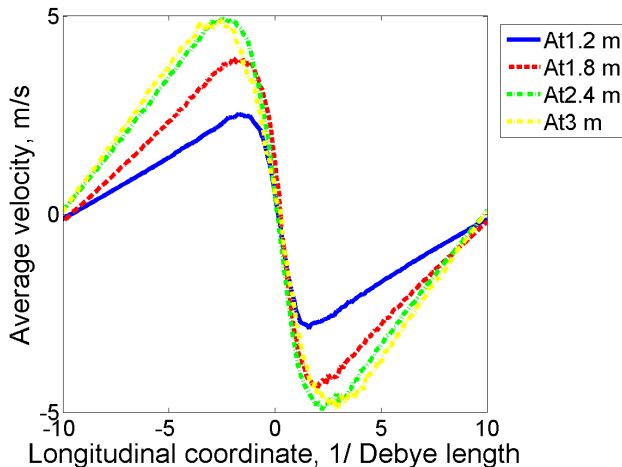
nz, ion at center



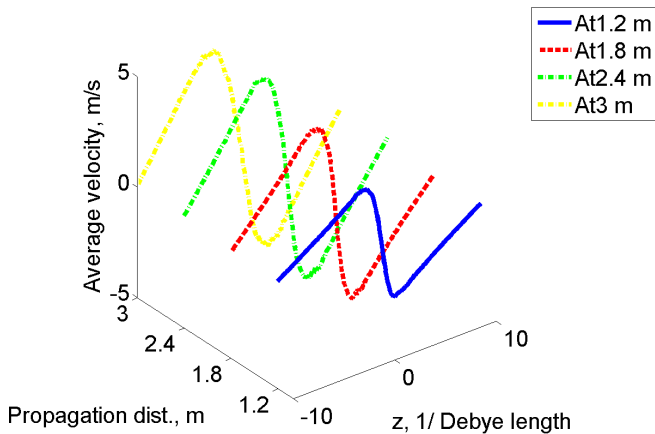
nz, ion at center



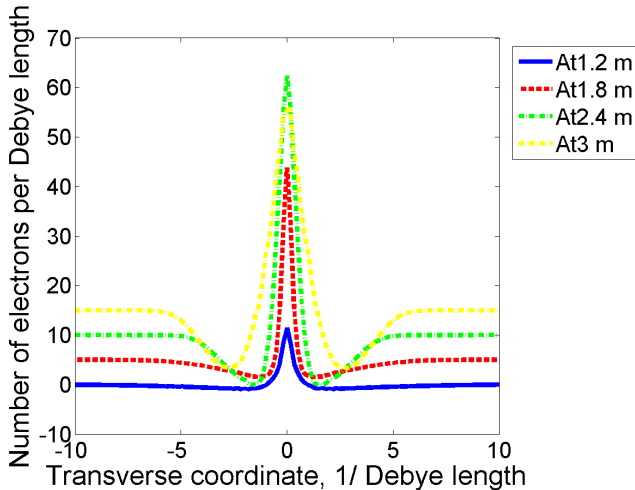
v_z , ion at center



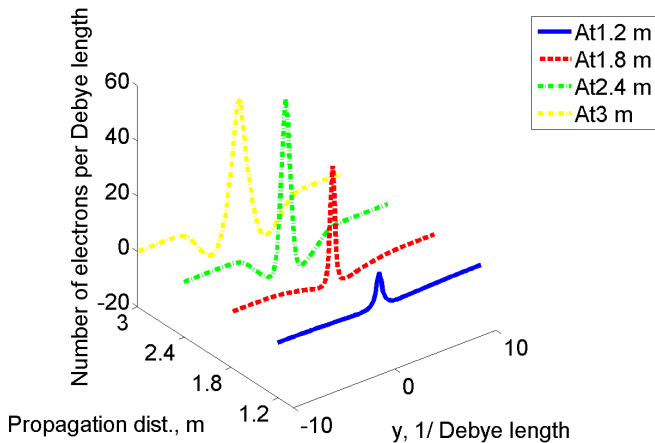
v_z , ion at center



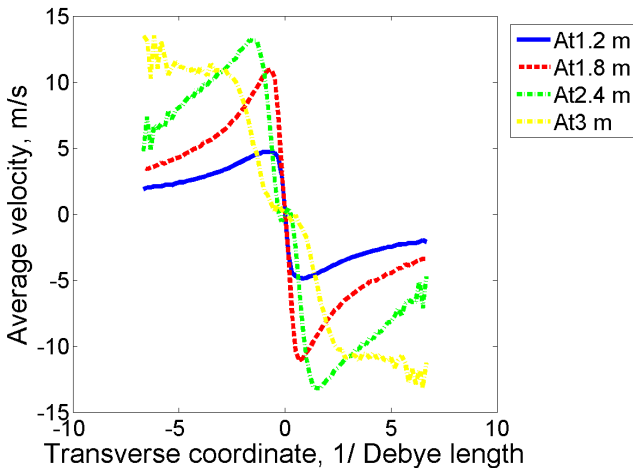
ny, ion at center



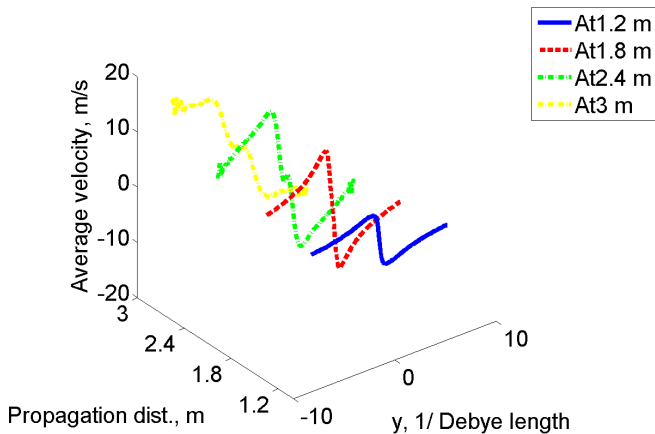
ny, ion at center



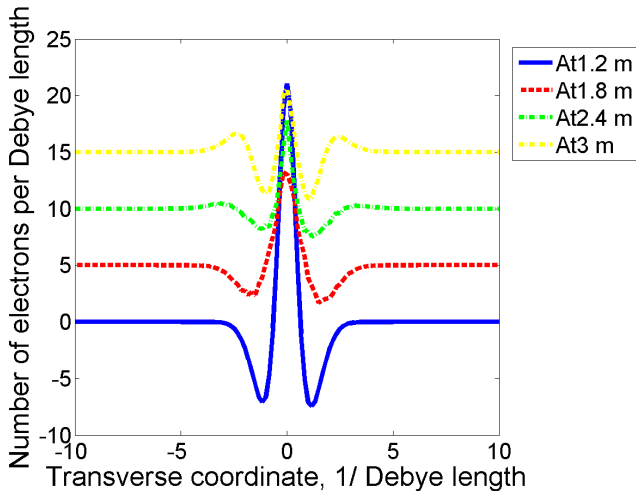
v_y , ion at center



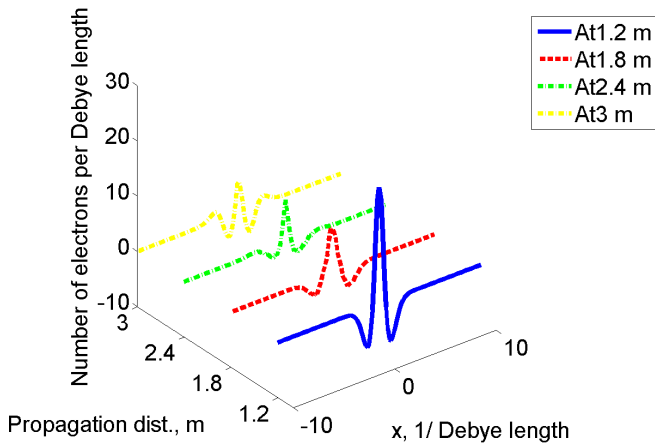
vy, ion at center



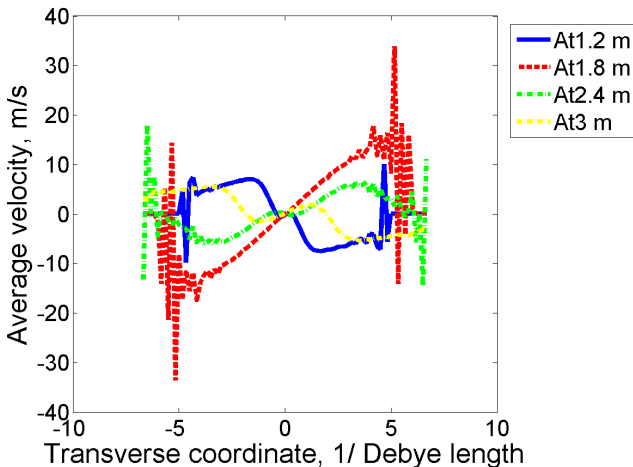
nx, ion at center



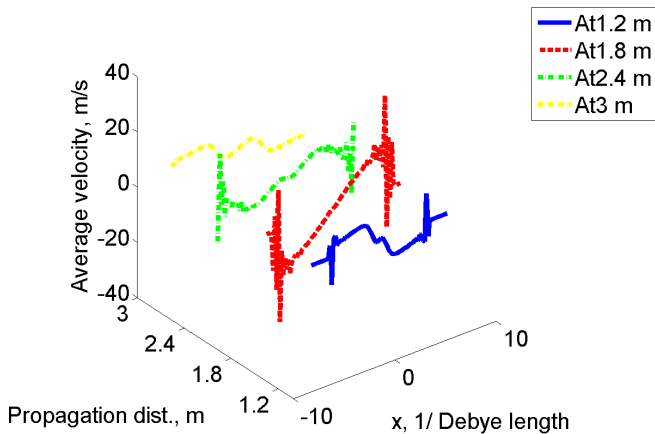
nx, ion at center



v_x , ion at center



v_x , ion at center



Quadrupoles makes phase advance

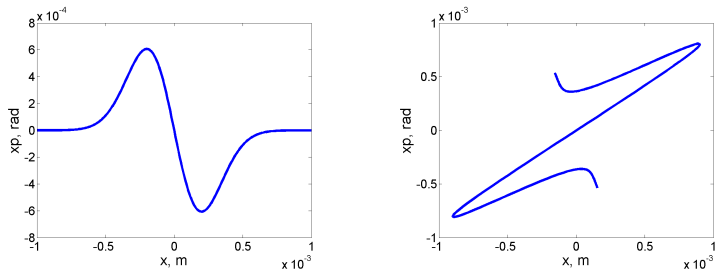
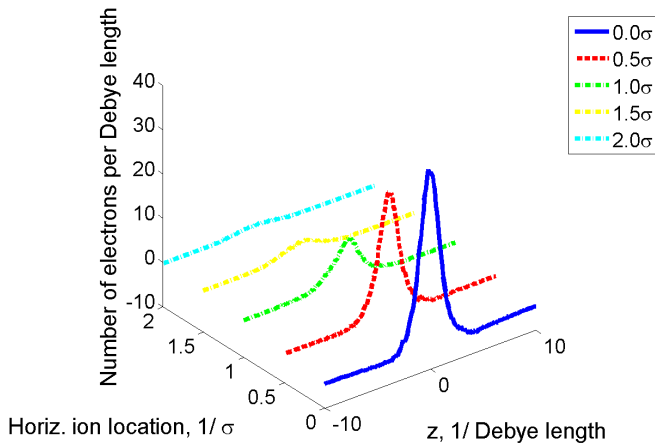
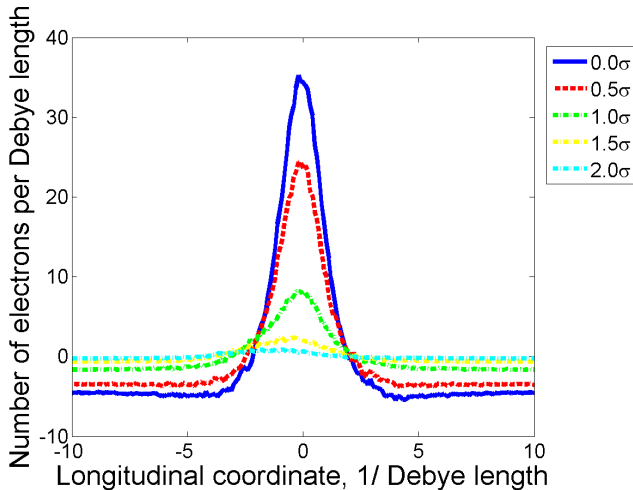


Figure: Initial (left) and final (right) phase plots of modulation signal

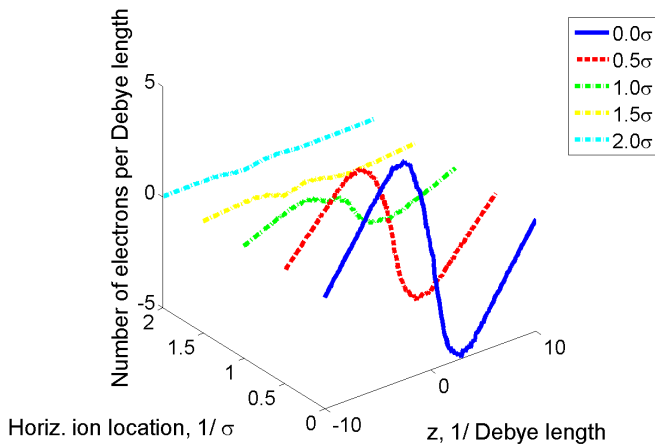
nz, various ion locations



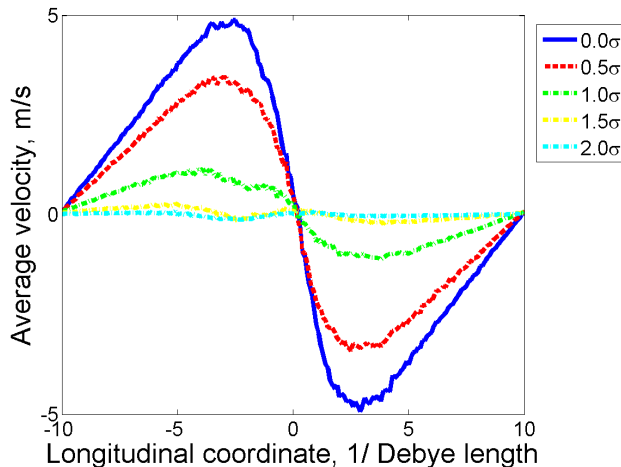
nz, various ion locations



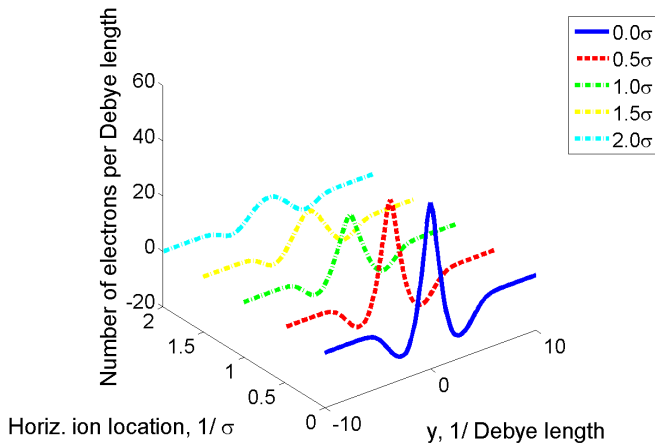
vz, various ion locations



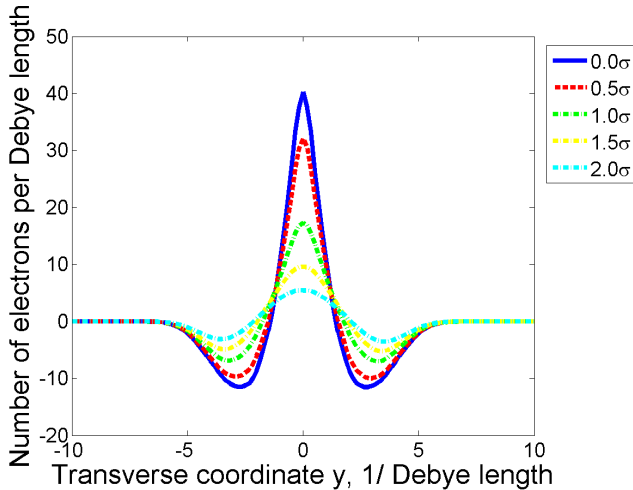
v_z , various ion locations



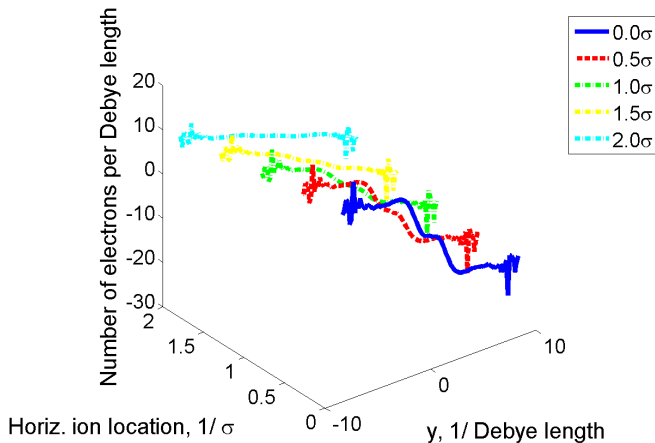
ny, various ion locations



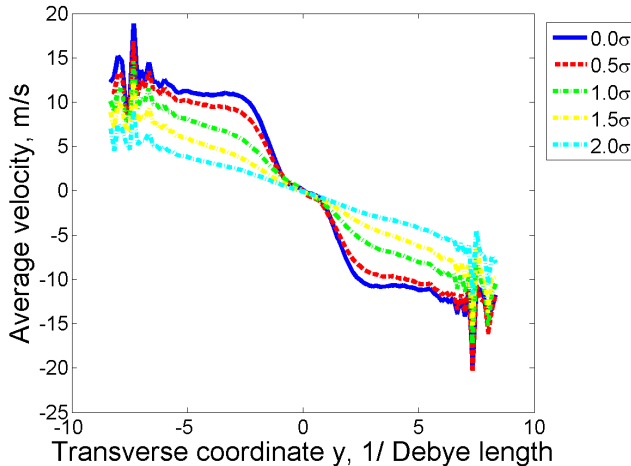
ny, various ion locations



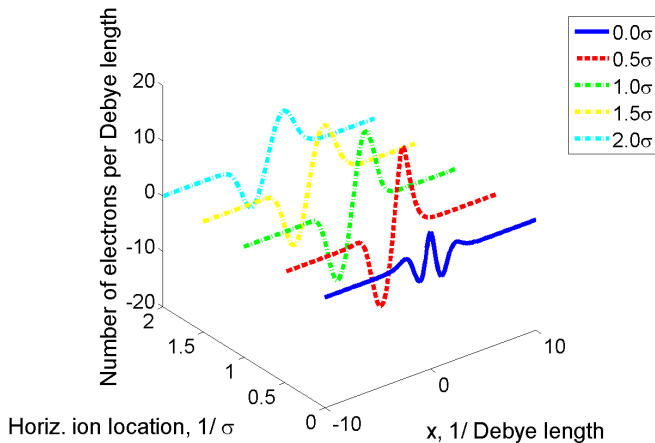
v_y , various ion locations



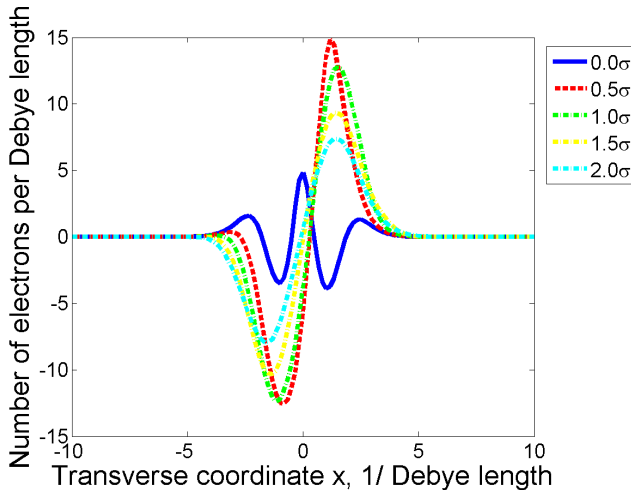
v_y , various ion locations



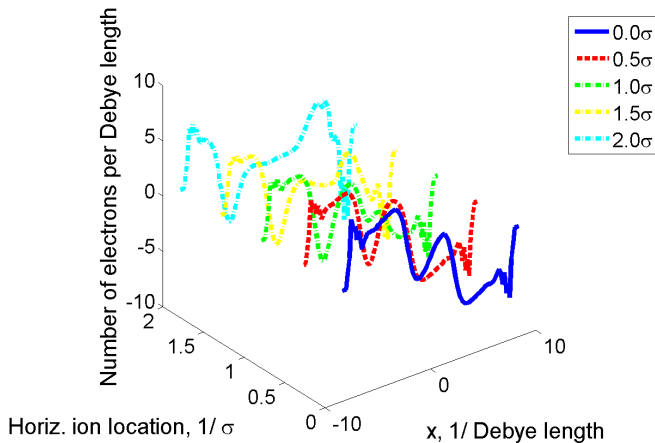
nx, various ion locations



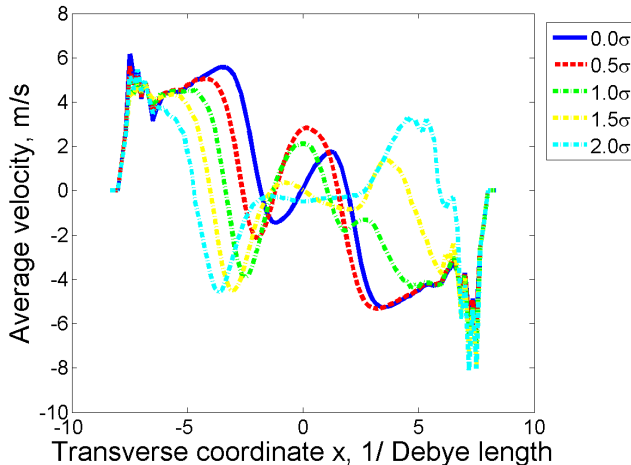
nx, various ion locations



v_x , various ion locations



v_x , various ion locations



More results

- More ion locations
- Moving ion

Modulator(SPACE) \Rightarrow Amplifier(GENESIS) \Rightarrow Kicker(SPACE)

GENESIS parameters

- Optical wavelength (slice length), 1.357e-5[m]
- Number of slices, 400
- Bunching factor of j th slice

$$b_j = \frac{1}{N} \sum_{k=1+jN}^{(j+1)N} e^{i\theta_k}$$

- Wiggler period, 4[cm]
- Number of wiggler period, 200 / 188 (8[m]/7.5[m])

Wavelength

$$\lambda = \frac{\lambda_u}{2\gamma^2} \left(1 + \frac{K^2}{2} \right)$$

$$\lambda = 1.357e - 5[m]$$

$$\lambda_u = 4e - 2[m]$$

$$K = 0.7$$

$$K = \frac{eB_0\lambda_u}{2\pi mc}$$

$$B_0 = 0.2[T]$$

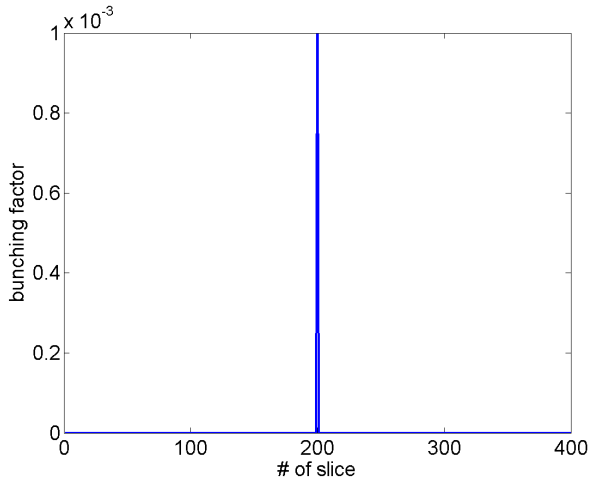
Modulator to FEL

- Let GENESIS generate particles for 400 slices
- Replace one slice with distribution from modulator simulations (background beam and modulated beam)
- Run GENESIS with replaced slice
- Take difference between background beam and modulated beam

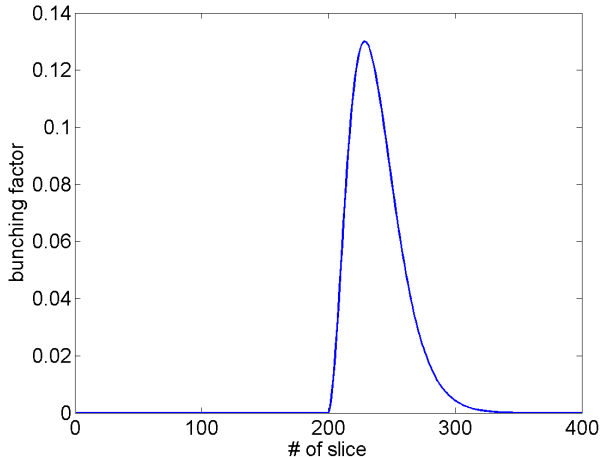
FEL to kicker

- Take the output of GENESIS as the input of kicker simulation
- Run kicker simulation

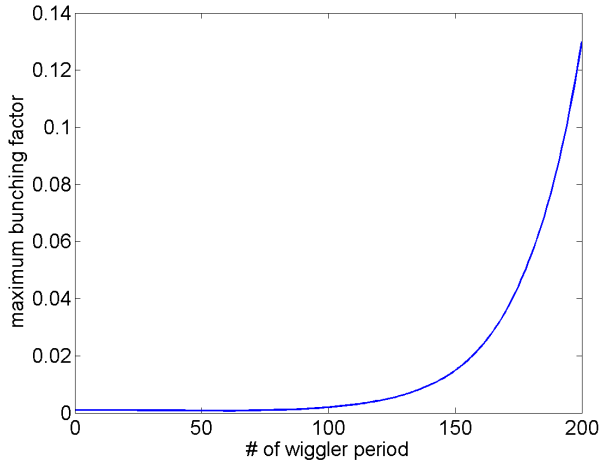
Initial bunching factor in FEL



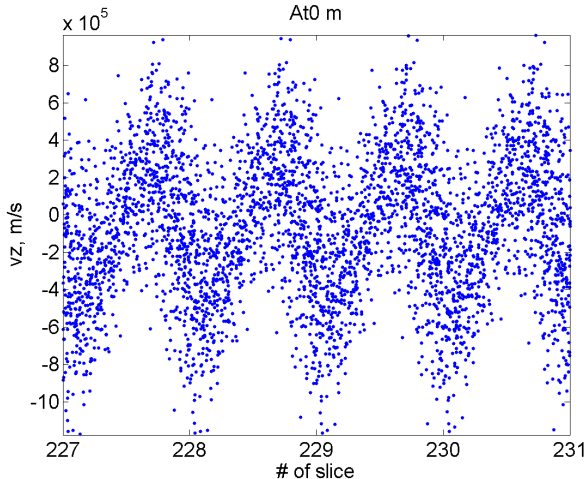
Final bunching factor in FEL



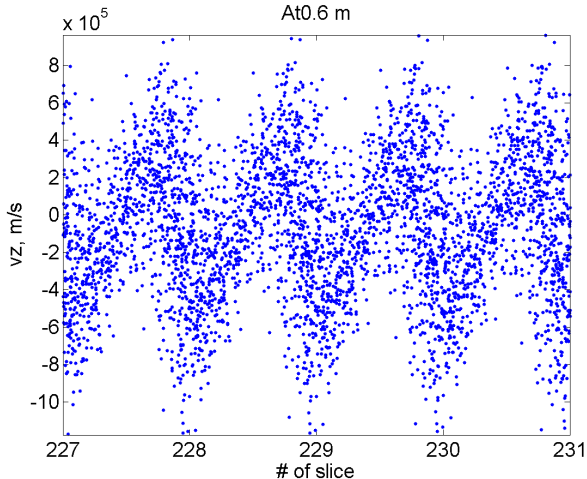
Bunching factor changes in FEL



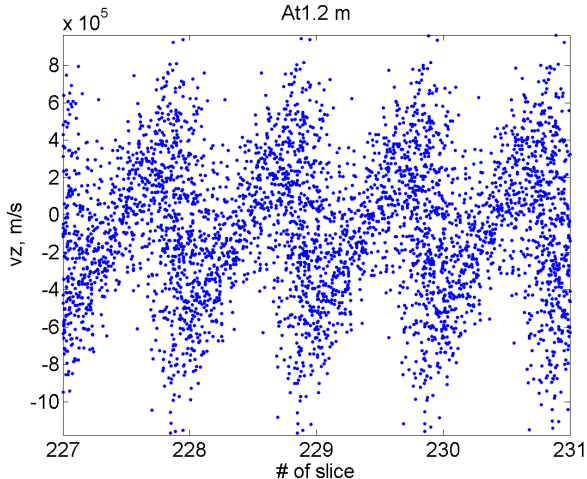
$z - v_z$ plot in kicker



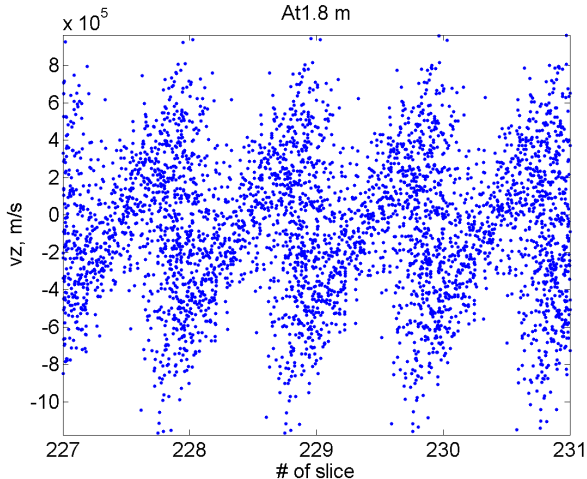
$z - v_z$ plot in kicker



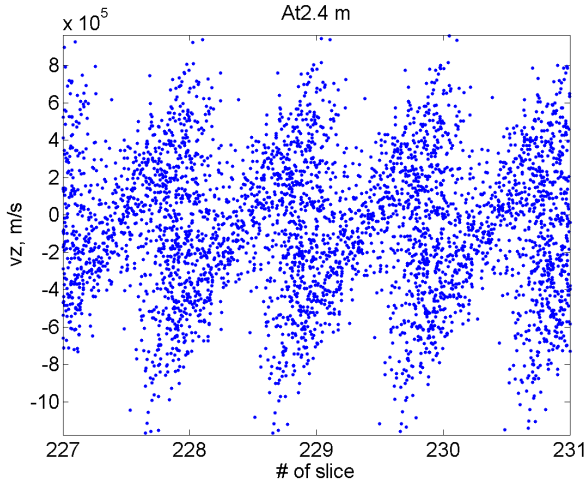
$z - v_z$ plot in kicker



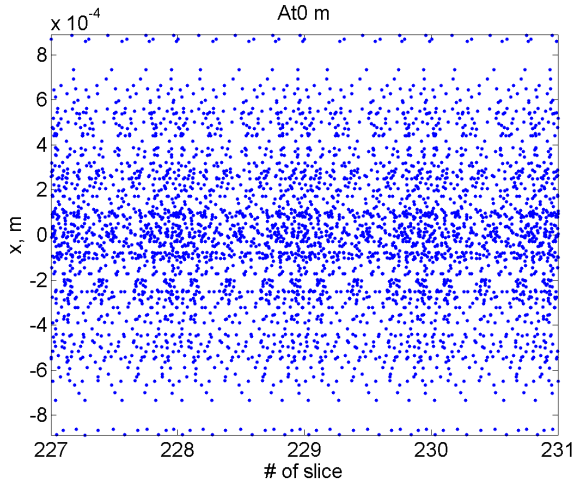
$z - v_z$ plot in kicker



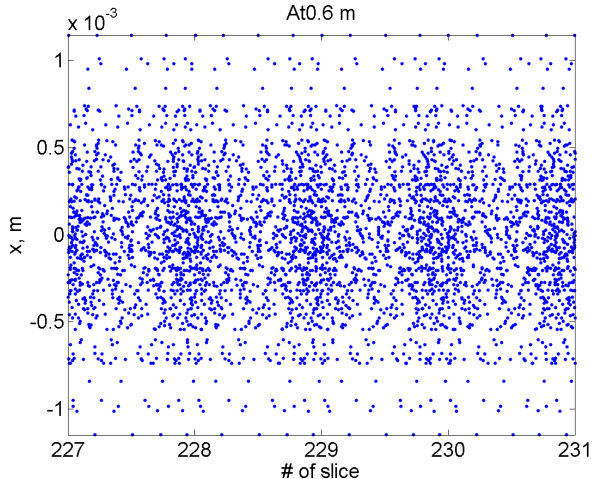
$z - v_z$ plot in kicker



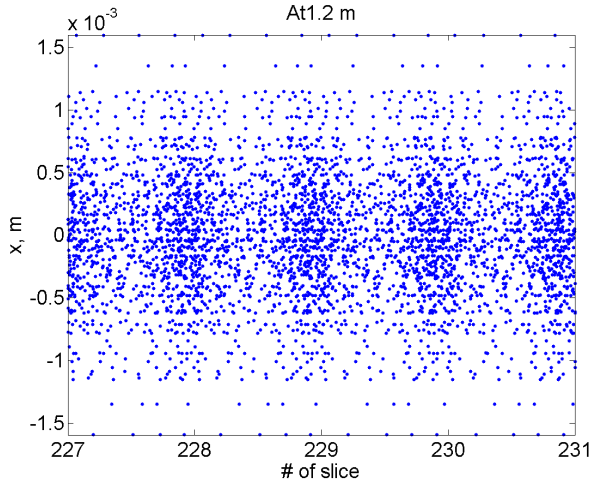
$z - x$ plot in kicker



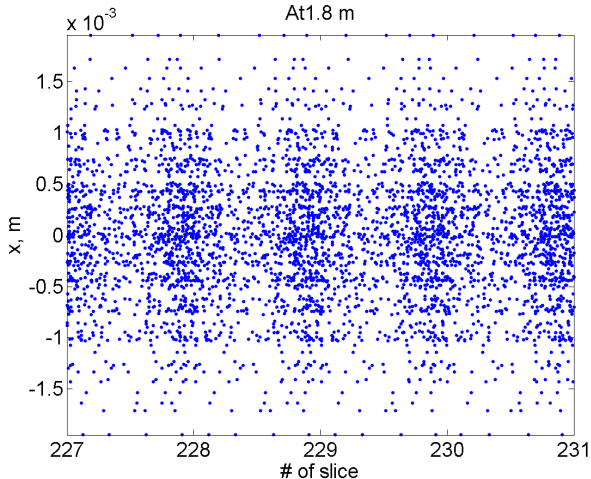
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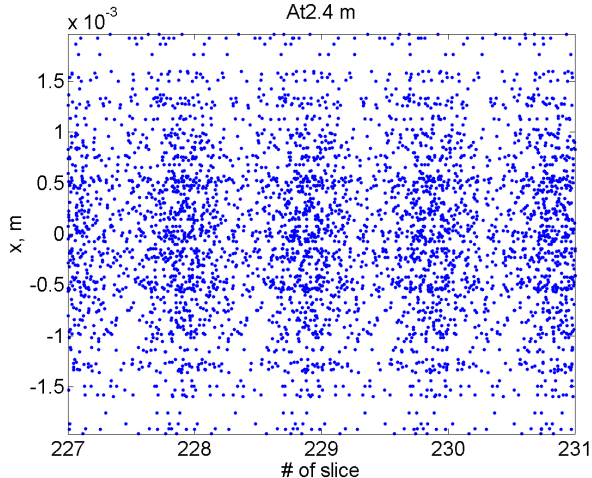
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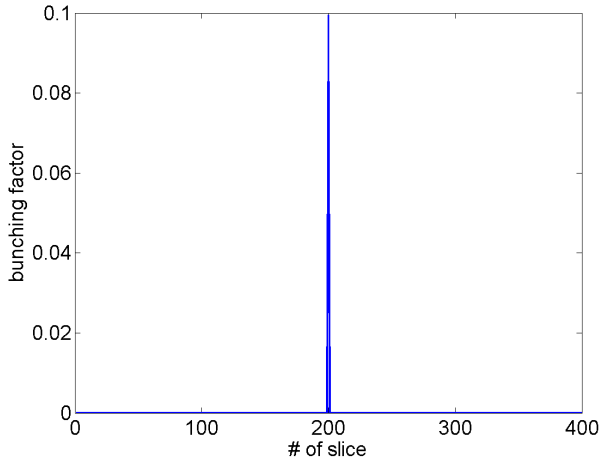
$z - x$ plot in kicker



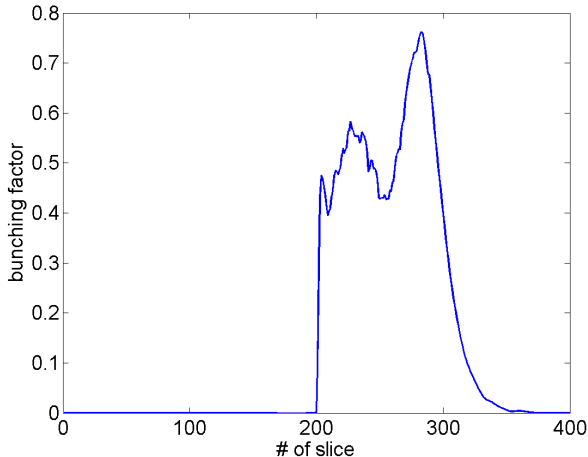
$z - x$ plot in kicker



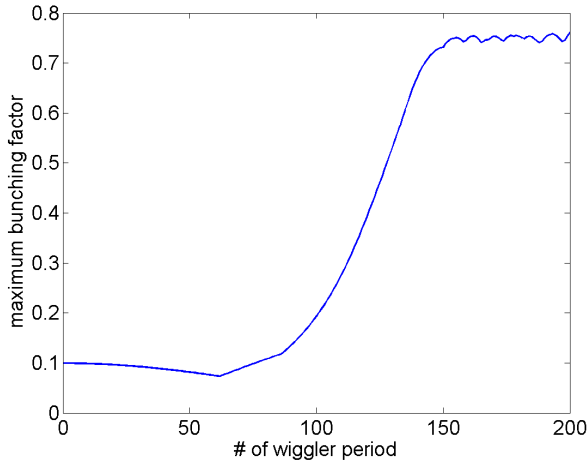
Initial bunching factor in FEL



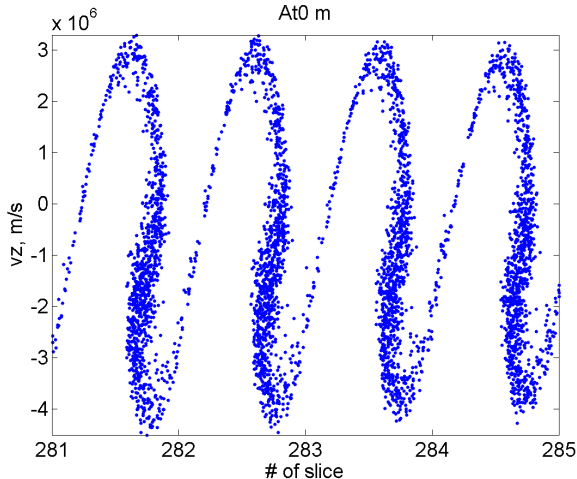
Final bunching factor in FEL



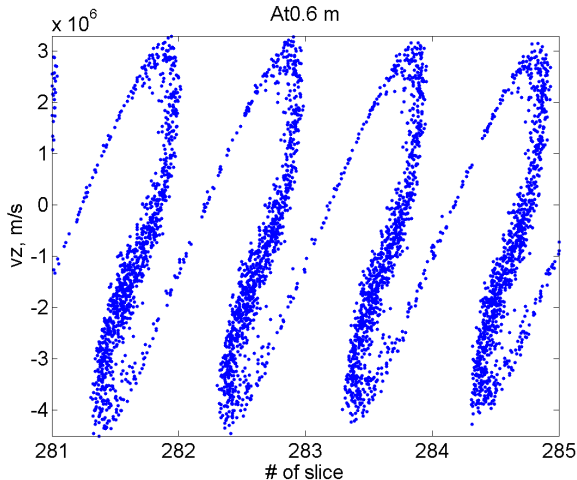
Bunching factor changes in FEL



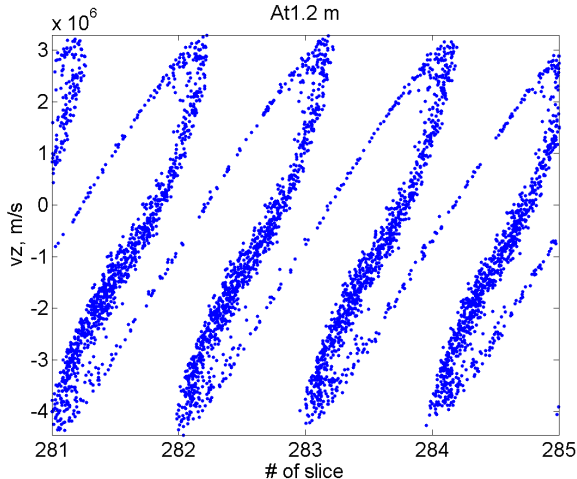
$z - v_z$ plot in kicker



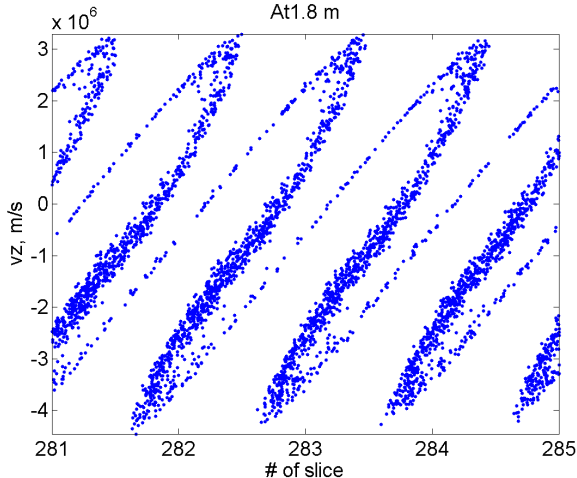
$z - v_z$ plot in kicker



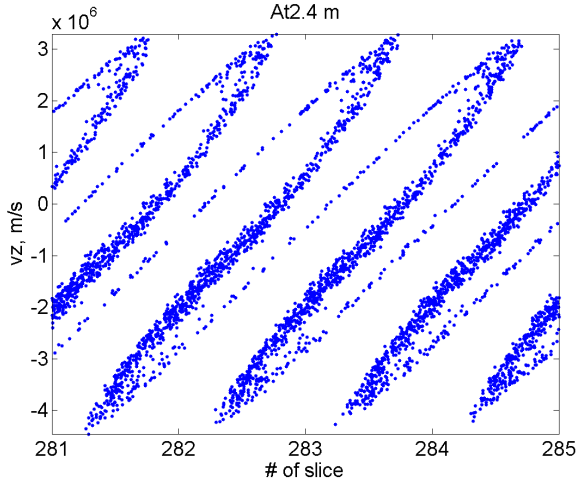
$z - v_z$ plot in kicker



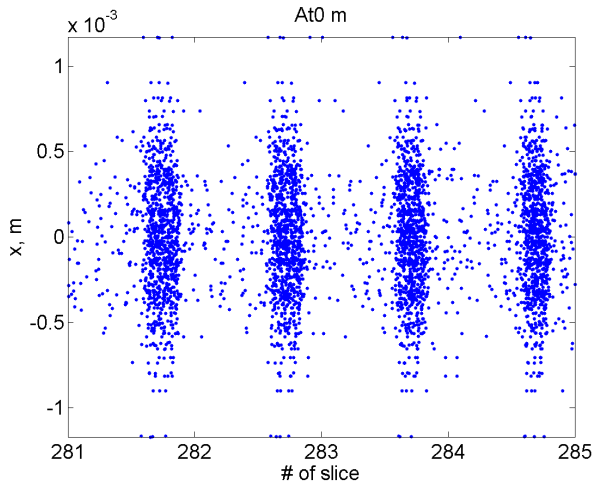
$z - v_z$ plot in kicker



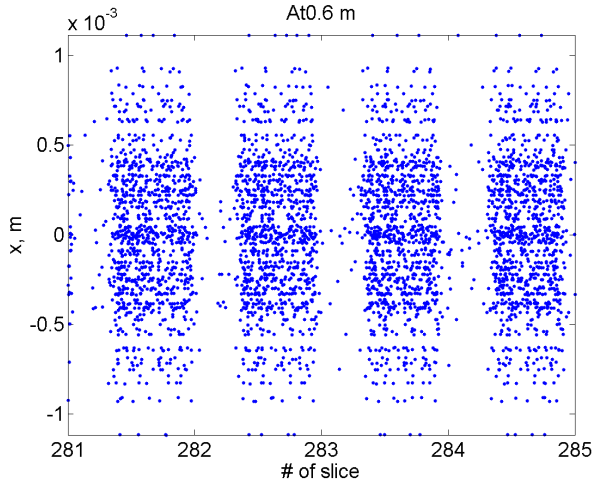
$z - v_z$ plot in kicker



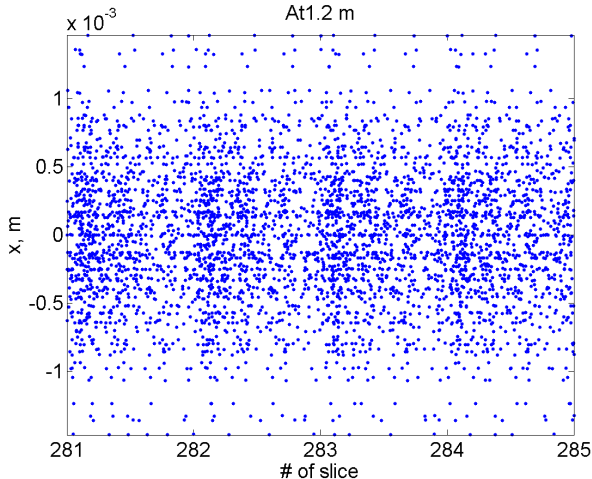
$z - x$ plot in kicker



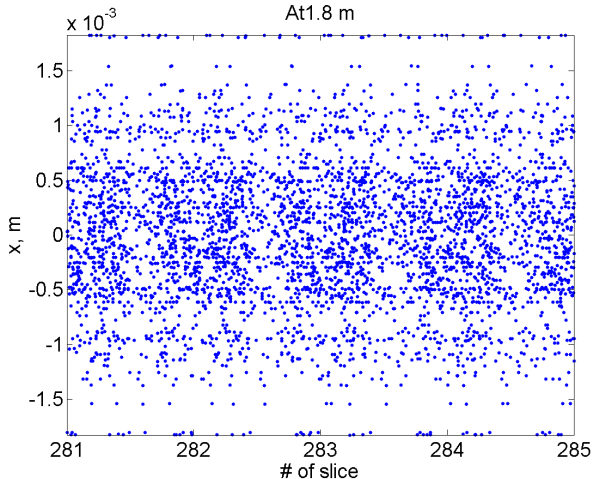
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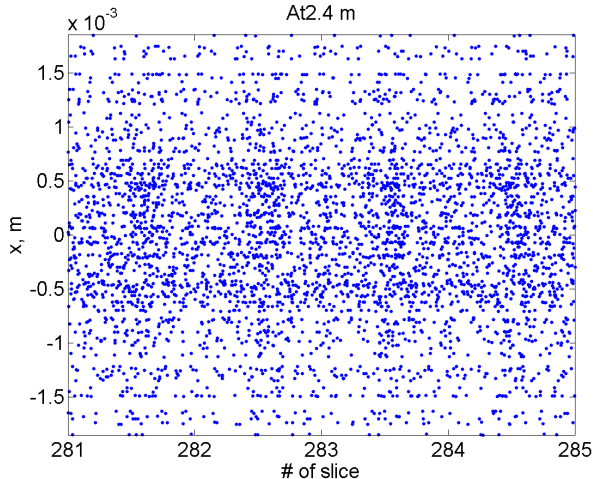
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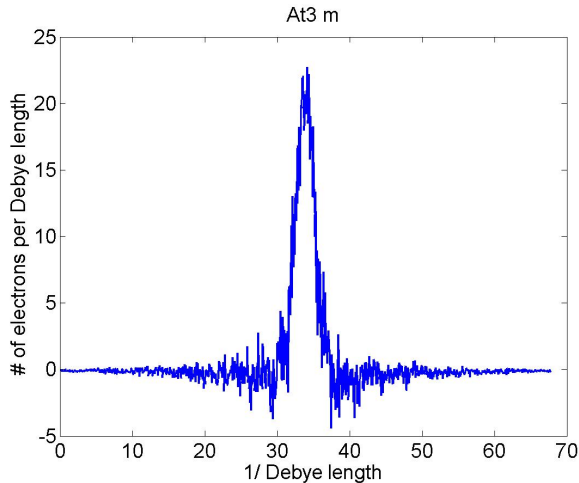
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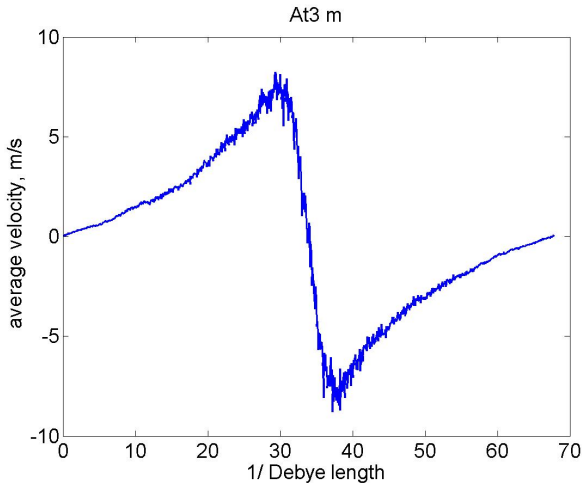
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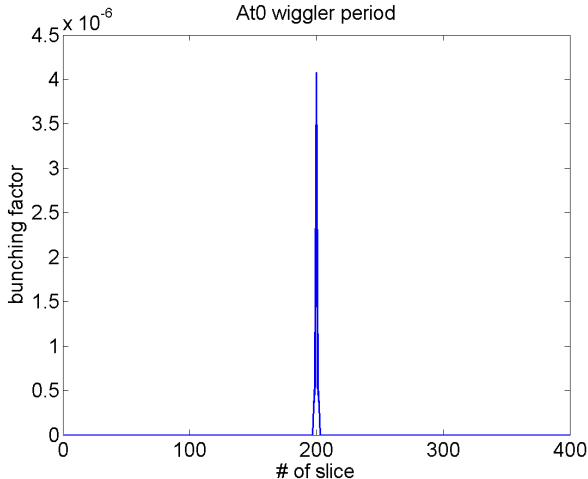
nz in modulator



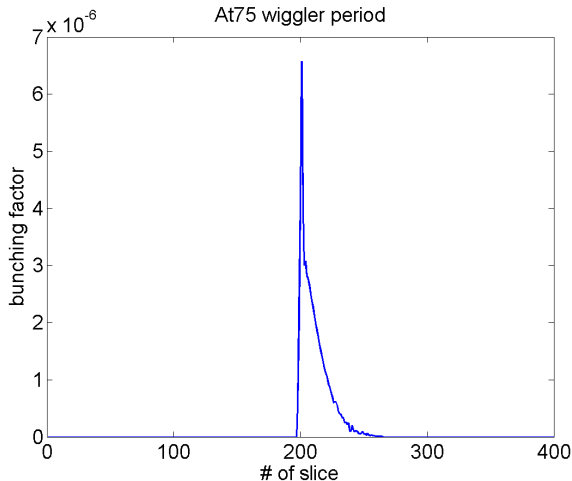
vz in modulator



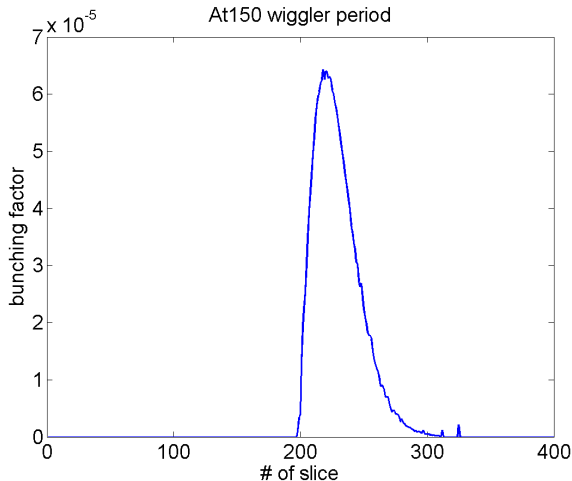
Bunching factor in FEL



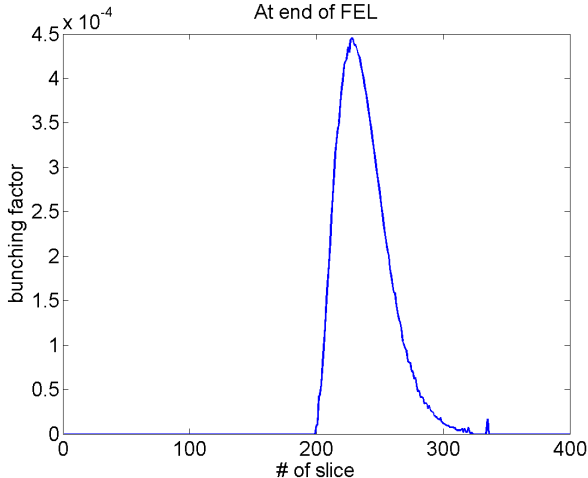
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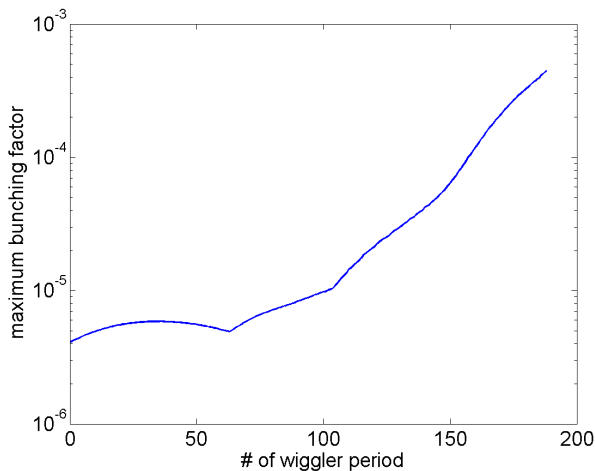
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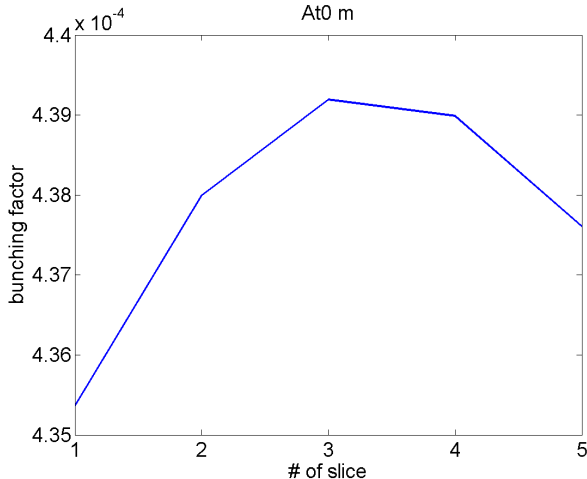
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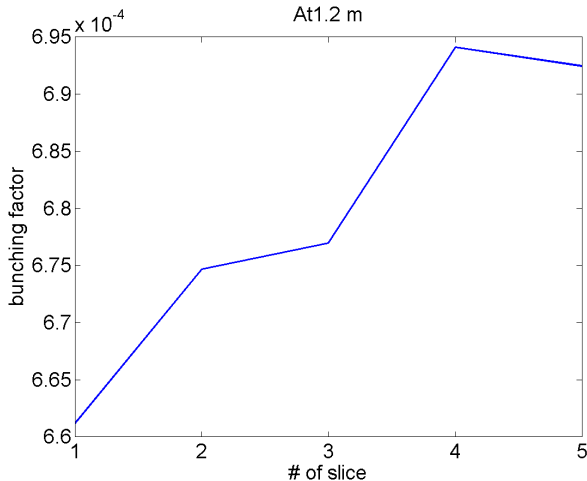
Bunching factor changes in FEL



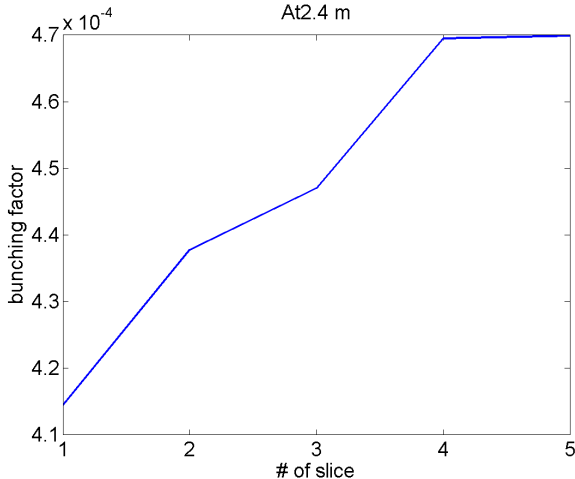
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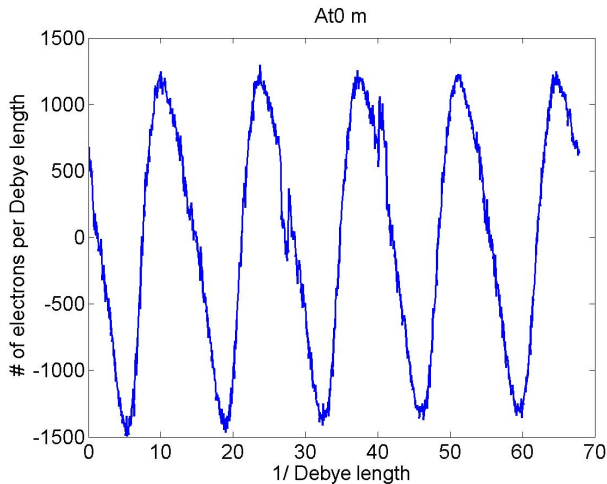
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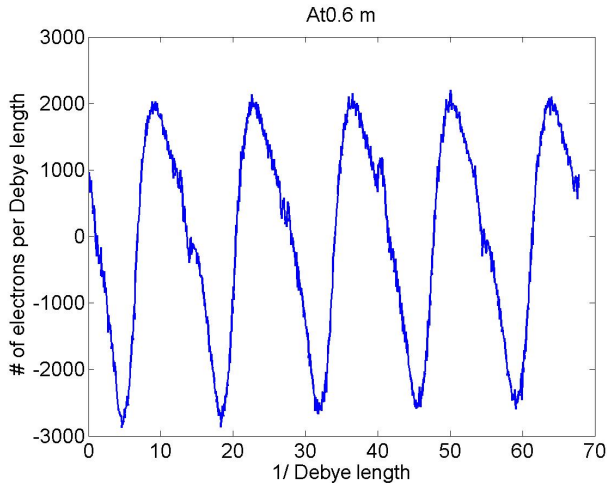
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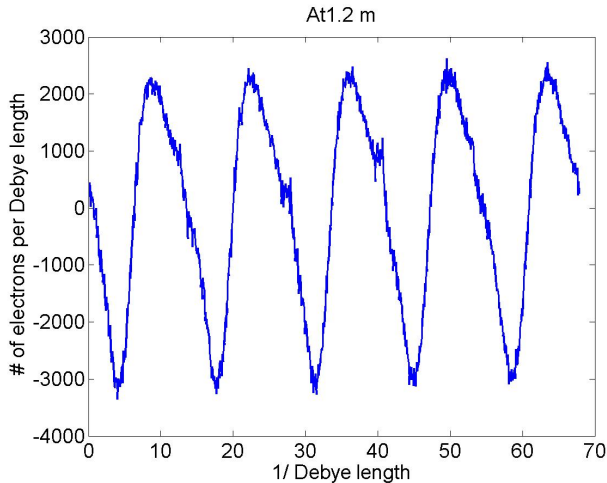
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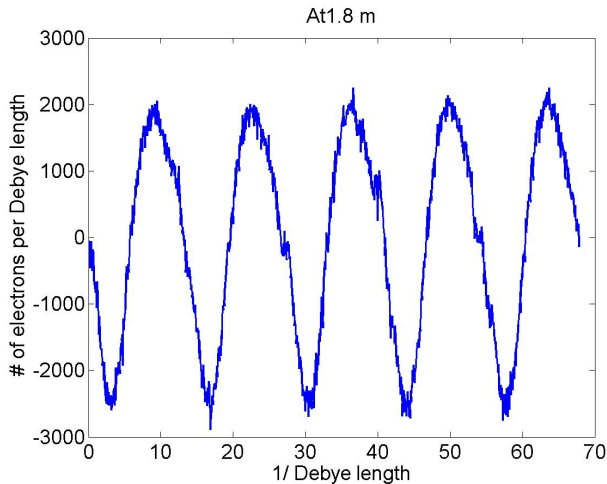
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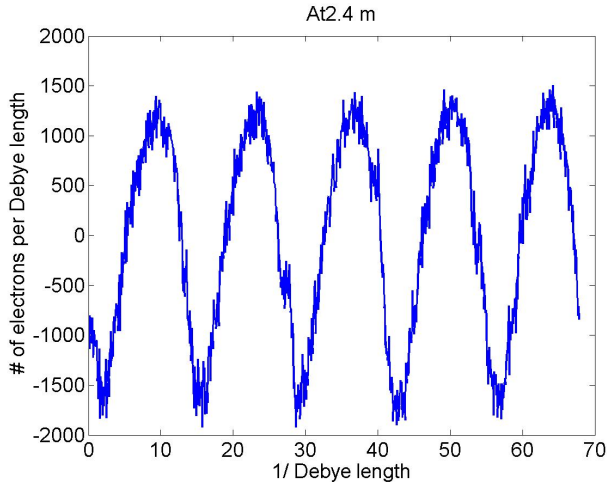
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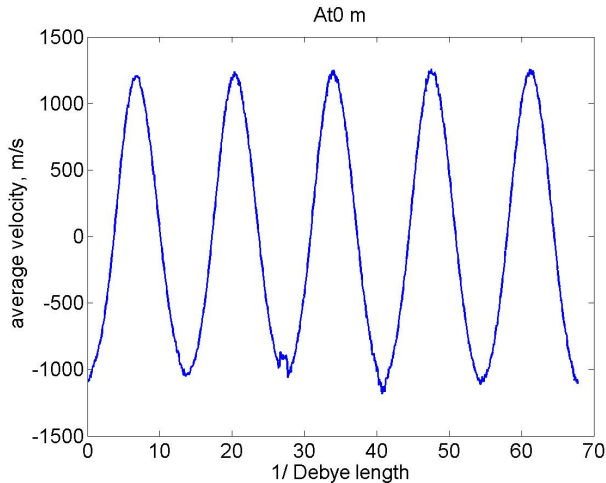
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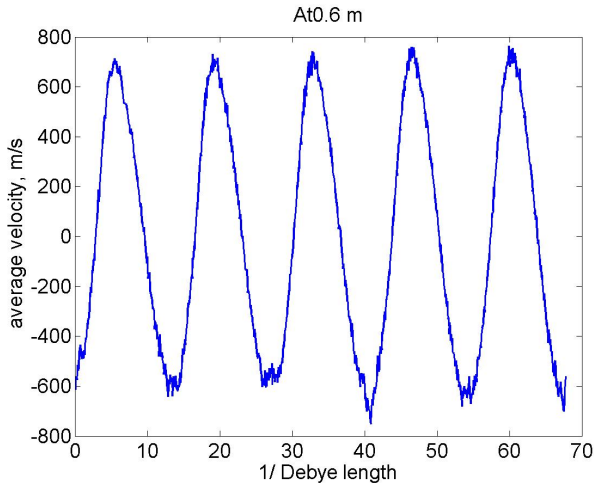
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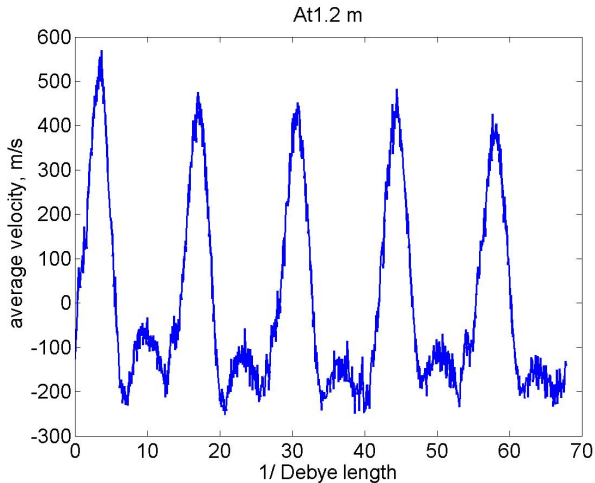
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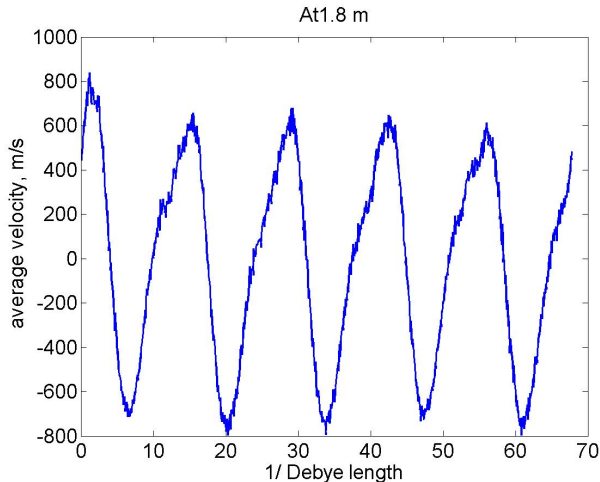
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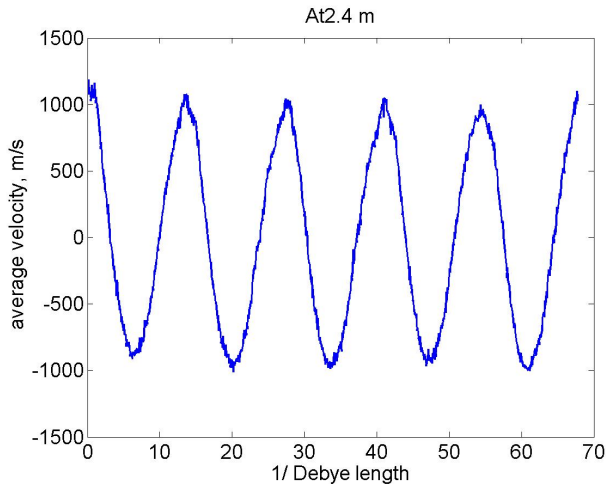
vz in kicker



vz in kicker



vz in kicker



Conclusion

- Modulator simulations using uniform electron beam
Obtain agreement with theory
- Modulator simulations using Gaussian electron beam and continuous focusing
Better understand modulation process
- Modulator simulations using Gaussian electron beam and quadrupoles focusing Give predictions for CEC experiments
- Connecting SPACE and GENESIS
Capable of doing start-to-end CEC simulations

Future work

- Use real beam distribution as input
- Use various locations and velocities of ion

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THANK YOU !